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Author Zhang, Xiang

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UNIVERSITY OF CALIFORNIA, SAN DIEGO

Design, Analysis and Application of System-Level Power Distribution Networks

A dissertation submitted in partial satisfaction of the requirements for the degree Doctor of Philosophy

in

Electrical Engineering (Computer Engineering)

by

Xiang Zhang

Committee in charge:

Professor Chung-Kuan Cheng, Chair Professor Bill Lin Professor Patrick Mercier Professor Yuan Taur Professor Michael Taylor

2017

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Chair

University of California, San Diego

2017

DEDICATION

To my family.

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VITA

2008	B. Eng. in Electronic Engineering, Shanghai Jiaotong University
2010	M. S. in Electrical and Computer Engineering, University of Arizona
2011-2014	Senior Engineer, Qualcomm Technologies Inc
2012-2015	Ph. D. student, University of California, San Diego
2014-now	iPhone Hardware Systems Design Engineer, Apple Inc
2015	C. Phil in Electrical Engineering (Computer Engineering), University of California, San Diego
2015-2017	Ph. D. candidate, University of California, San Diego
2017	Ph. D. in Electrical Engineering (Computer Engineering), University of California, San Diego

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ABSTRACT OF THE DISSERTATION

Design, Analysis and Application of System-Level Power Distribution Networks

by

Xiang Zhang

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Professor Chung-Kuan Cheng, Chair

The design of power distribution networks (PDNs) has become increasingly complex and less margin, as the CMOS technology node continues to scale down into 10nm and below and the operating voltage of high-performance (HPm) logic keeps decreasing. As circuit density on a single chip doubles every two to three years, the current density is growing rapidly as well. Thanks to the emerging of the application of machine learning and deep learning, more and more logic blocks, such as application-specific or heterogeneous integrations are needed on future application processors(APs). All of the above require a better design and analysis of methodology for PDNs.

In this dissertation, we address design and analysis of PDNs from the whole electronic system, including board level, package level and die level designs. First, we analyze the mathematical relation between time-domain voltage response and the frequency-domain impedance of PDN. We also propose a method to fast estimate the worst-case PDN noise for industrial PDN models and extend PDN design and analysis by considering the impact of on-die leakage of PDN. Second, we discuss the PDN design applications by predicting the longest delay of a datapath due to the worst-case noise area of the supply voltage. Third, we propose power line communication (PLC) to reuse part of PDNs and package to package capacitive communications as data transmission channels to increase the off-chip bandwidth during SOC low performance state.

Chapter 1

Introduction

1.1 Power Distribution Network in System Integration and VLSI Design

Power distribution network (PDN) has become one of the most critical topics in nano-scale VLSI design. With the continuous scaling of CMOS transistor technology and the recent advances of 3D-IC technology, the current density of a single chip keeps increasing while the operating voltage of high performance processors is gradually dropping. This results in the target impedance of a PDN in 2026 to drop more than five-fold from that value in 2011 (Figure 1.1), which brings us an even tighter noise margin requirement. The higher frequency leads to an ever increasing dynamic supply switching noise. The ITRS roadmap shows that the operating voltage of high-performance (HPm) logic will move to 0.73V in 2018 [3], which brings us an even tighter noise margin requirement. As a result, minimizing IR drop and antiresonance peaks caused by parasitic resistance, loop inductance and decoupling capacitance have become extremely critical to maintain a robust circuit performance.



Figure 1.1: Target impedance prediction according to ITRS. Assume $Z_{target} = \frac{V_{dd} \times 5\%}{I_{load}}$

Meanwhile, the full-chip leakage power in 2016 is predicted almost three times as what in 2011 as shown in Table 1.1 [3, 35], indicating that on-die leakage is no longer negligible for PDN analysis. Therefore, minimizing IR drop and simultaneous switching noise (SSN) of a PDN caused by leakage and parasitic resistance, loop inductance and transient currents have become extremely important.

System-level PDN design is extremely critical for the consumer electronics design, such as mobile devices, laptops, IoT and game consoles. A large portion of design material cost is dedicated to power delievery. Figure 1.2 shows the bottom side of the logic circuit board of a iPhone 7^{TM} teardown. Chip inside the green

Yr. of Production	2011	2012	2013	2014	2015	2016
Leakage Power	1.00	1.00	1.27	1.45	2.18	2.91

Table 1.1: Full-chip leakage power (normalized to full-chip leakage power dissipation in 2011).



Figure 1.2: A main logic board for iPhone 7TM. Courtesy of www.ifixit.com

area is a power management IC (PMIC). Lots of decoupling capacitors for PDN are placed in the region which is at the back side of the SOC. Figure 1.3 shows a $Snapdragon \ 600 E^{\text{TM}}$ SOC pin assignment [2], 50% of SOC balls are allocated for power and grounds to accommodate the highest performance state and different voltage domains.

Based on this findings, we can conclude that industrial design has been taking seriously consideration for system-level PDN performance while delivering large quantity and high quality products, and open up the question whether we

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28	DNC	DNC	62910 <u>7</u> 8	ß	PCDQ15	EBI0_ PCDQ13	PCDQ11	PCD00	EBI0_	EBI0_	EBD_	PCODT0	EBI0_	E810 PCK1	PCCNEO	EBI0_ POCK0	EB 0_ PCBA2	EB 0 PCODTI	EBI0_ PCDQS2	EBN PCDO23	EB 0_ PCDQ21	EB 0 PCDQT9	EB 0	GND	GND	GND	DNC	DNC	*
22	BNC	DNC	CP 10_73	TRST_N	CCK	EBI0_	EBI0 PCDQ12	EBI0_	EBI0_ PCDQB	EBI0_	EBI0_	EBI0_	EBI1_CH0	EBI0_ PCCK1B	EBI0 PCCKE1	EBI0_	EBI0_ PCBA0	EBI0_PCBA1	EB0_	EBI0_ PCDM2	EBI0_ PCDQ22	PCDO20	EBI0 PCDQ18	EBI0_ PCDQ16	GND	GP10_19	BNC	×8	12 punc
26	SDC1_	SDC1	CP10_75	N_TSPS	R	ผ่างงา	PCDQ29	DNC	GND	DNC	EBI0_ PCDQS3	DNC	GND	BIC	DNC	GND	DNC	PCDQSB0	DNC	GND	DNC	RB 0	GND	GP10_10	C010	01-01-01	œ_olao	CN CN	8
38	SDC1_ DATA_6	SDCI DATA_1	SDC1_ DATA_5	¥.	PMC	EBI0_	EBI0 PCDQ28	BNC	EBI0_	DNC	EB0_	DNC	EBI0_ PCA7_	N	DNC	EB0_	DNC	PCDQ50	R	PCDOS	BNC	PCDO2	EBI0 PCDQ0	GPI0_12	64 ⁻ 00/	GPI0_11	6PIO_5	GND	8
24	SDC1_ DATA_2	PCDQ16	SDC1	SDC1_ CMD_	SDC1_ DATA_4	₽	PCDQIG	EBI0_ PCD027	EB 0	DNC	GND	PONE	EB D	DNC	DNC	EBI0_ PCM3_	000	GND	BNC	EB 0 PCDQ7	EB D	PCDQB	9 ⁻ 0140	GP10_23	GND	GP10_26	GP10_4	G	24
8	EB1_ PCDQ17	PCDQ18	GND	PCD00	SDCI_DATA_0	6PIO_78	0HD_74	EBI0_ PCDQ26	EB0_	DNC	EB0_	VDD	EB0 PCA6	EB0_ PCA11	EBI0_ PCA12	EB0_ PCA4	DOV DOV	EB0	R	EBI0_ PCDM0_	EBI0	GND	6PI0_24	GPIO_9	06_010	GPI0_21	GPIO_2	GND	8
22	EBI1_	PCDQ20	PCDQ1	PCD02	PODOS	GP10_76	GND	14 ⁻ 00/	GND	GND	EB0_	VDD_ KR3_SNS	GND	BBI0 PCA10	EBI0 PCA13	GND	VDD_ KR1_SNS	EBI0_ PCA14	GND	GND	14 [°] 007	GND	GP10_25	GP10_86	GPI0_3	GP10_13	GND	GND	8
21	EBH_ PCDQ21	EBH	DNC	S	PCDO	EBI1_ PCDQ4	14 ¹ 00v	VDD CORE	и"онр	RTCK	TCK	NBW	VREF	RESOUT	MODELO	NODE	RESIN	14 ⁻ 00/	GPIO_87	GPIO_82	GPIO_83	DNC	DNC	GP10_8	GPI0_22	DNC	PCI_E HSO_N	HSC R	anect 21
20	EB1_ PCDQ23	PCOM2	GND	EB1_ PCDG5	EBH PCDO7	PCOMO	GND	80 ⁻ 00A	VREF	2014	GND	NDD_P1	CORE	EB10_ PCCAL	64 ⁻ 00A	GND	VDD PLL2	GND	VREF	GP10_84	GP10_18	GND	54 ⁻ 00A	GND	GND	GND	PG_E_ REFCLK	PG_E REFCLK	8 8 8
19	EB1_ PCDQ52	EBH PCDQSB2	DNC	BIC	DNC	BIC	BNC	1000	NEW OCA	CND	VDD_KR3	VDD_KR3	GND	GND	אסם או	אסס"אנו	GND	NBM	64 ⁻ 004	GND	GND	DNC	DNC	DNC	DNC	DNC	HSI N	n al	°
18	EB1_ PCODT1	EB11_PCBA1	PCDQSB0	PC0081	GND	PCM	POA14	USB2 HSIC_ CAL	VD0_	GND	VDD_KR8	NDD_KR8	NBM.	QND	NDD_KR	VDD_KR1	NBM	14 ⁻ 007	QND	GND	NDOA_	VID0_A2	PCI E REXT	VDDA_ PCIE	GND	GND	GND	g	a ala
44	EBI1_ PCBN2	EBI1_	DNC	DNC	PCA0	DNC	DNC	GPI0_89	VDD_ CORE	CND	GND	VDD	GND	CORE	GND	GND	CND	VDD_ CORE	V00 CORE	GND	VDD_ SATA	DNC	DNC	SATA_ TPA	DNC	DNC	SATA_ ROP	ROM	17 Multi
16	PCCM0	EB1	GND	BII. PCM	EB1	PCM	QN O	VD0_P4	VDD_ CORE	GND	VDD_KR2	VDD_KR2	- NBM	Q	VDD_KR0	оня дал	GND	NDD_ OCIV	80	MOH	GND	GND		SATA_ REKT	SATA_ CLIM	SATA_ CLKP	SATA_ TOM	SATA_ TXP	\$
15	EBI1_	EBI1_	DNC	DNC	DNC	EB1 PCA12	EB1 PCA13	69 IO 88	M3M _001	CND	VDD_KR2	VDD_MR2		GND	ORD_ DOV	069 GOV	CND	GND	OX4	GND	NDA MOH	HDMI TX2_F	HDMI TX2_M	DNC	DNC	DNC	MON INT	MOH IMOH	15 support
2	EBH_ PCK1	EB1_ POCK1B	DNC	DNC	DNC	EB1_ PCA11	EB1 PCA10	PMIC	LT14 ND0 ⁻	NDD_ PLL2	GND	GND		GND	GND	GND	VDD_ PLL2		PXO _OUT	GND	HDMI TYD_M	HDMI TX0_P	LVDS_ TX4_M	DNC	DNC	DNC	HDMI_ TCLK_M	HDMI TO.K.P	Memory
13	EBH_ PCCS0N	EBI1_	GND	BBII_ POA7	PONS	POM6	GND	64 ⁻ 00A	GND	VID PILI2	GND	V00 CORE	VID CORE	GND	GND		VDD	GND	00A 0Xd		HDMI	TX4_P	SQV1	N SXC	50VI	M_8XT	5001	LVDS_ TV7_M	\$
12	EBI1_ PCODTD	EBI1_	DNC	DNC	EBH PCAB	DNC	DNC	GPI0_72	NBM_	GND	GND	VDD CORE	VDD_ MBM_	GND	GND	VDD	NBM_	GND	GND	LVD8 TX1_M	TX1_P	DNC	DNC	LVD8	DNC	DNC	LVD6_		12 Inctions
	PCCASN	PORASN	PCDQS3	EBI1 PCC0385	GND	EBH_ PCMG	PCRSTN	100 M	EBH_	VDD	VDD_ CORE	GND	GND	VD0 CORE	VDD CORE	GND	adsop	ADD ODSP8	VDO	LVDS TX0_M	TX0.P	GND	LVDS TX2_M	VDD_	LVDS TX3_M	LV08	C.K0_P	LVDS_ CLK0_M	11 Internal fi
10	EBI1_ PCDQS1	EBH PCDQSB1	DNC	NC	DNC	DNC	DNC	GPIO_36	GND	VDD CORE	VD0_	GND	GND	VDO	NBM	GND	V00 PLL2		GND			DNC	DNC	DNC	DNC	DNC	MPI DSD IN1_N		\$
6	FCDM1	EBI1_ PCDQB	GND	EBI1	EBH PCDQ24	EBH_ PCDM3	ß	CP10_14	VDO	VREF	GND	GNSS BB QP	GNSS 198 1	NOUV	MLAN MLAN	MLM.	GND	VREF_ DDR_C0	VDO	MIPL DSI_ CAL	ND0_MPI		N_0S0 DS0_ NIPI	MPL_0S0_0S0_	NIPI DISID	USO OSO	NP DSD CIK_N	MPI_ DS0_ CLK_P	• 8
8	RBH_	PCDQ10	DNC	DNC	PC0027	BH_ PC0036	14 OQ	GPIO_80		GND	GND	GNSS BB_QM	GNSS GNSS	GND	WD_88		WLAN	100 P1	GND	IdW OOA	GND	DNC	NIPI_ THSO LNO_N	MIPL_ DSH_ DSH_	DNC	DNC	MPI_ DSH_ CLK_N	MIPL DSH CLK_P	e 6
7	EB1_	EB1	EB1	EBI1_ PCDQ28	PCDOID	GPI0_1	QND	Ha OQV	GND	DNC	USB3_HS REKT	DNC	Sd9	QND	GND	WLAN RECT	DNC	GP10_47	BNC	19 DO	DNC		NIPL_ INSO	MPI_ DSH_ UN1_P	MPL. DSH	MPI_ DSH_ UN3_P	MPL. DSH LN2_N	MPL DSH 1/2	-
9	EBH_	BII _	GPI0_61	BU PCD001	0 040	GPIO_15	ano a	85 OKD	84 ⁻ 00/	DNC	GND	DNC	VDD_ USBPH74 _ 1P8	GND	VDD CORE	GND	DNC	GPI0_42	BNC	GP10_28	GP10_39	GND	GND	GND	MIPI- CSI0_ LN2_N	MIPL CSI0 LN2_P	MPI_CSID_CSID_	MPI CSI0 LN3 P	6 terfaces
8	EB1_ PCDQ15	GP10_36	GND	200 P3	GP10_37	VDD_P2	GP10_55	GPI0_59	QND	DNC	UBB3_HS _VBUB	VDD	UBB4_HS _VBUS	ž	N	USB1_HS _VBUS	54 OQV	GPI0_52	Se la	vDD_P3	GPI0_45	GP10_46	IdIW ⁻ 00A	MPI_ CSI0_ LN0_P	MIPI_ CSSI0_ LIN1_N	MPI CSI0	MPI_CSIO_CSIO_CILK_N	MPI_CS0_CS0_	s Chipset in
*	GP10_71	GP10_38	GP10_70	BNC	90	GND	vrer_ spc	DNC	V00_	DNC	аг sн ^г asn	DNC	GI- SH_MSU	DNC	DNC	ai SH_18SU	DNC	GP10_51	DNC	GND	DNC	GP10_64	wcn_xo	GND	MPL_CSI0_	GND	MPL CSIT	MPI CSH LN0 PI	-
•	GPIO_69	GP10_34	GPI0_16	GPI0_17	GPI0_81	VDD_ CORE	ar,	BNC	VDD USBPHY3 _1P8	DNC	GND	DNC	USB1_3 4_HS SYSCLK	BK	DNC	USB1_HS REXT	DNC	GPI0_50	B	GPIO_28	DNC	GP10_66	GPI0_67	GPI0_41	GND	GND	MPI_CSI1_CSI1_	CSR MP	a cévity
2	DNC	DNC	CXD_EN	BNC	DNC	SDC3_	SDC3_DATA_0	SOCI	GND	NG_ DM_HS	GND	Md_ DM_HS	GND	GND	MQ_ DM_HS	GND	GP10_54	GND	GP10_49	GP10_68	GP10_27	GP10_65	GP10_63	GP10_40	GND	MPL CSH LN1_P	DNC	DNC	2 Connes
-	NC	DNC	DNC	GPIO_62	GPIO_S7	SDC3	SDC3_DATA_2	GND	VDD BBPHY3 3P3	DP DP	VDD_ USBPHY4 3P3	USB4_HS	LISB4_HS REXT	VDD SBPHY1 3P3	DP HS	VDD USBPHY1 _1PB	GPIO_ES	GPIO_48	GPIO_43	GPIO_22	GPI0_38	GPIO_44	GPIO_30	GPIO_31	GND	MPL CS1	BNC	DIC	-
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Figure 1.3: Snapdragon $600E^{\text{TM}}$ pin assignment.

can utilize power and ground pins dynamically to improve off-chip communication bandwidth.

1.2 Current Research Efforts

Power distribution network has been a critical topic for both academia and industry for many years. In order to meet more and more aggressive voltage scaling and current demand in system level design, power integrity engineers are looking for new manufacturing technologies, design methodologies and fast simulation to improve the robustness of PDN.

From manufacturing technologies perspective, deep trench capacitors [43, 31] and on-die regulators [58, 11, 65] have been proposed to reduce the impedance profile of PDN. Intel has been reported to use fully integrated voltage regulator (FIVR) in the latest desktop chipset [47, 42]. Although on-chip capacitors can provide the best PDN noise decoupling performance, the amount of on-chip capacitance is greatly limited by die area. FIVR is also susceptible by thermal runaway for mobile and IoT applications. Advanced packaging technologies, such as flip chip [64], package decoupling caps [13] and package-on-package (POP) [71], have been widely applied to reduce the parasitic resistance and inductance of the PDN. From system level design, multi-phase buck regulators and remote feedback [46] has been applied to compensate the PCB or system level DC losses. Remote feedback usually comes with a strict requirement on phase margin for the feedback network and buck output capacitors.

From design methodologies perspective, one hot research topic is to bridge the gap between PDN measurement and simulation correlation [38, 34], and application specific PDN design methodologies. Cai [12] proposed to design DDR memory rail PDN based on signaling timing margin. Goral *et al.* [27] studied PDN simulation through IC behavior model. Based on modern IC design flow, an early PDN analysis without netlist information is very important for floor-planing and chip area estimation. Ko *et al.* [40] proposed a simplified chip power model as a function of leakage current, operating frequency and the measurement data from the previous generation chip. Lalgudi *et al.* [45] initiated a finite-difference formulation based on the latency insertion method (LIM) has been employed for simulating the power-supply noise in the on-chip PDN. However, most of those early prediction work requires a knowledge of circuit information that might cause confidentiality problems for the intellectual property (IP) from the industry perspective, and insufficient for application as a solution for SoC design because of the shortage of time caused by silicon delivery.

In the area of PDN simulation, there are two main research directions: frequency-domain (FD) analysis and time-domain (TD) analysis. For FD analysis, Larry Smith was the first to propose the concept of "target impedance" [62]. Many studies have been extended based on this concept [37, 54, 62, 63, 56]. Kim *et al.* [37] proposed a design methodology for optimized power distribution networks based on frequency-domain PDN resonance information. His method applies to high Q (quality factor) LC tank model without equivalent series resistance (ESR) considered. Kim *et al.* [34] gave a closed-form expression for supply noise caused by IC switching current for a PDN structure. Sun and Smith [60, 61] proposed a method to systematically characterize on-chip PDN noise and generate a worstcase current pattern. However, none of the methods has been able to derive the worst-case PDN noise from system level because such methodology assumes that there is a limit on PDN noise as long as the design is below target impedance in impedance profile. In one of our works, we demonstrate that there is no limit on the ratio of worst-case noise to the target impedance [73], as the shape of the impedance profile also matters.

TD provides a more realistic PDN noise analysis as the worst-case load current may not happen at all. For example, there is a lot of fast-transient load on a typical CPU current load, while a GPU current profile tends to have more low frequency content as the rise and fall time are much longer. TD analysis is widely used in design verification. Such research topics focus on finding worst-case noise based on intensive simulation. For the simulation-based verification approach, one needs to know all possible current waveforms drawn by the circuits. The requirement of a complete set of possible current stimuli makes the simulation-based approach intractable, especially for large designs. Moreover, PDN verification must be signed off at an early design stage, when full knowledge of load currents is hardly available due to PVT (process, voltage and temperature) variations. Ghani and Najm [26, 23] found a vectorless approach to obtain the upper bound of the worst-case noise without any simulation based on given load current constraints. Zhuang and Cheng [77] proposed a distributed framework for transient simulation of power distribution network, which utilizes matrix exponential kernel with Krylov subspace approximations to solve differential equations of linear circuit.

1.3 Dissertation Outline

Chapter 2 introduces the background of system-level power distribution networks. The basic concepts of power delivery and the modeling and analysis of PDNs are briefed. An overview of power line communication was given.

Chapter 3 analyzes the mathematical relation between the time-domain voltage response and the frequency-domain impedance of PDN and discuss the

closed-form expressions of the maximum ratio for the series RL/RC circuit and LC tank cases in PDN structures. A method is proposed to predict the worst-case noise of the complete PDN path through cascaded LC tank model. The relation of on-die leakage resistance and PDN performance is also discussed.

Chapter 4 proposes a prediction of the worst-case noise area of the supply voltage on PDN. Previous works focus on the worst-peak drop to sign off PDN. In this chapter, we (1) compare the behavior of circuit delay over the worst-area and the worst-peak noise (2) study the different PDN models with theoretical derivation (3) develop an algorithm to generate the worst-case current for general PDN cases. Experimental results show that the worst-area noise induces an average 18% additional delay than that of the worst-peak noise.

Chapter 5 demonstrates power line communication (PLC) on a industrial SOC PDN. We propose to reuse some of the power pins as dynamic power/signal pins for off-chip data transmissions to increase the off-chip bandwidth during SOC low performance state. The performance of PLC model and the impact to PDN are investigated. The parasitic capacitance of the power gating switches is studied in the model. We also study the receiver channel equalization to improve channel performance.

Chapter 6 introduces Inter-Package Capacitive Proximity Communication to boost off-chip communication through the metal plates on the side wall of the package. The proposed architecture can transmit 20Gbps data on each channel and provide immunity to the coupling noise from adjacent channel, without adding additional cost or reliability The performance and design area trade-off is also discussed.

Chapter 7 concludes the dissertation by summarizing the main contributions. Future research directions are also discussed.

Chapter 2

Background on Power Distribution Networks

2.1 Power Distribution Network Basics

A power distribution network (PDN) is a network to supply power to high performance system level circuit design. The system supplying power to an IC can greatly affect the performance, size, and cost characteristics of the overall electronic system. The PDN may consist of a voltage regulator module (VRM), on-die load, broad/package parasitics and on-die power grid with decoupling capacitors as shown in Figure 2.1. A VRM can be a buck/boost converter or LDO, which depends on the tradeoff between the noise requirement of the load and power efficiency of the system.

During chipset design stage, architects need to take into account the power network parameters from regulator, board, package to chip level. Lumped model is widely used in system level PDN analysis [55, 62, 34, 67]. As shown in Figure 2.2, a typical PDN can be represented by multi-stage cascaded LC tanks. Since each



Printed circuit board

Figure 2.1: A cross-sectional view of power distribution network for high performance integrated circuits [66].

RLC tank has one anti-resonance peak, multiple impedance peaks are observed from impedance profile. The overall worst-case noise is a cumulative effect of multiple anti-resonance peaks [73]. Thus, a clear understanding of single LC tank circuit effect becomes extremely important.

For simplicity, VRM is represented as a DC source, which is equivalent to AC short in impedance profile for PDN analysis. For complicate industrial designs, designers must also consider static load/line regulation, dropout voltage and power supply rejection ratio (PSRR) of the regulators into PDN design margins. The power load is modeled as time-variable current source i(t). The interconnect lines that connecting the supply and the load are not ideal, which includes DC resistance and loop inductance on power and ground traces from PCB, package and die level. Resistive IR voltage drops $\Delta V_R = IR$ and inductive switching voltage drops $\Delta V_L = Ldi(t)/dt$ develop across the parasitic interconnect impedances, as the load sinks current I(t) from PDN. Therefore, the voltage levels across the load terminals change from V_{dd} at the source to $V_{dd} - IR - Ldi(t)/dt$. Note that $R = R_p + R_g$ and $L = L_p + L_g$, where R_p , L_p and R_g , L_p are the resistance and inductance of power and ground respectively. To mitigate the power supply noise, decoupling capacitors



Figure 2.2: A circuit diagram characterizing the impedance of PDN.

are added in different level of the designs to counteract the impedance increase causing by the parasitic inductances. ΔV_R cannot be mitigated by decoupling capacitors, however, remote feedback at the load for buck regulators is widely applied in industry to compensate ΔV_R . Figure 2.3 shows a typical GPU load current profile from one power pin. [39].

Figure 2.4 shows a PDN with two-stage RLC tank. Following the normal PDN distributions, we assume that $L_1 \gg L_2$ and $C_1 \gg C_2$, as we have $L_{brd} \gg L_{pkg} \gg L_{die}$ and $C_{brd} \gg C_{pkg} \gg C_{die}$ for typical PDNs. In Eq. 2.1 we define ω_a and ω_b to be the two resonant frequencies, Q_a and Q_b to be the quality factors of the low-frequency and high-frequency tank respectively. The contribution of each circuit component to the impedance profile is labelled in Figure 2.5.

$$\omega_{a} = \frac{1}{\sqrt{L_{1}C_{1}}} \ll \omega_{b} = \frac{1}{\sqrt{L_{2}C_{2}}}$$

$$Q_{a} = \frac{1}{R_{1}+R_{3}}\sqrt{\frac{L_{1}}{C_{1}}}$$

$$Q_{b} = \frac{1}{R_{2}+R_{3}+R_{4}}\sqrt{\frac{L_{2}}{C_{2}}}$$
(2.1)



Figure 2.3: A CPU load current profile measured on various power pins are shown in (a). The current spectrum for VDD pin 60 is shown in (b). [39]



Figure 2.4: A PDN with two-stage RLC tanks.



Figure 2.5: The impedance profile of a PDN with two-stage RLC tank.

2.2 Power Distribution Network Noise

Power supply noise, caused by the static and dynamic switching current, adversely affects the operation of an integrated circuit through several mechanisms. First, the propagation delay of on-chip signal transmission depends on the power supply voltage, as i_{ds} increases with V_{gs} . When the power supply voltage is reduced due to power supply variations, V_{gs} of the NMOS and PMOS transistors decreases, lowering the output current (i_{ds}) of the transistors. The signal delay increases accordingly as compared to the delay under a nominal power supply voltage. Conversely, a higher power voltage and a lower ground voltage shortens the propagation delay. Consequently, power supply noise limits the maximum operating frequency of an integrated circuit. We will discuss more on this topic in Chapter 4. Second, clock jitter increases as power supply noises increase. There are two types of clock jitters caused by power supply noise, *e.g.* cycle-to-cycle jitter and peak-to-peak jitter. Many research works have been studied in this area [66].

2.3 Power Distribution Network Applications

The Application Processor(AP or SOC) of a typical consumer electronic device allocates half of its BGA balls and PCB planes for power delivery. As a result, off-chip communication bandwidth is limited by number of pins and layers that signal can be routed. Furthermore, high-speed signaling also requires solid reference planes for controlled impedance. One reference plane for microstrip, and two reference plane for striplines, resulting in less available traces available for signaling. As we know, the increasing usage for memory-intensive applications such as web service, database, machine/deep learning (ML/DL) ad camera applications have forced computer architects to focus on ML/DL specific ASIC design. As



Figure 2.6: Off-chip bandwidth limitation. (Courtesy of Professor Yalamanchili)

showed in Figure 2.6, "Memory Wall", which describes the disparity between the rate of core performance improvement and the relatively stagnant rate of off-chip memory bandwidth, keeps increasing as more transistors can be designed onto a single chip due to the advance of process node (Figure 2.7). The intuitive solution for this problem is to provide more chip pins and routing channels for off-chip data communication. However, Figure 2.8 shows that the package size of SOCs remains similar as more functions are added to the silicon die and PCB manufacturing technology has been moderately improved, e.g., BGA ball to ball pitches are reduced from 0.4mm in 2012 to 0.3mm in 2016 in industry. As a result, we have proposed to use PDN for data communication during SOC low performance state in Chapter 5, and Capacitive Communication in Chapter 6.



Figure 2.7: The projection for the trend of the silicon process technology advancement. (Courtesy of ITRS)


Figure 2.8: The projection for package technology advancement. (Courtesy of Steve Bezuk)

Chapter 3

Ratio of the Worst-Case Noise and the Impedance of Power Distribution Network

The classic method of designing power distribution networks (PDNs) is to control the target impedance across a broad frequency range. This methodology is based on the assumption that there is an upper bound for the ratio of the timedomain maximum output voltage noise to the product of target impedance and time-domain maximum input current. In this chapter, we analyze the mathematical relation between the time-domain voltage response and the frequency-domain impedance of PDN. We present the closed-form expressions of the maximum ratio for the series RL/RC circuit and LC tank cases in PDN structures. We observe that the maximum ratio for LC tank case is 1.5. Our results show that the worstcase noise is not only determined by target impedance, but also depended on the shape of the output impedance profile. A complete PDN path is demonstrated with the worst-case ratio of greater than 1. We further propose a method to predict the worst-case noise of the complete PDN path. The average prediction error of the proposed method is 7% under different PDN cases.

3.1 Background

In PDN design, the target design objective is set as the time-domain supply noise amplitude. A typical range is 5% of nominal voltage for the digital systems. One of the most widely adopted PDN design methodologies is to follow the concept of target impedance of the PDN so that its output impedance is no larger than this target impedance over the whole operation frequency range [37, 54, 62, 63, 56]. The target impedance in the frequency-domain is expressed in terms of the current and target voltage tolerance in time-domain as follows [37]:

$$Z_{target}(\omega) = \frac{(power \ supply \ noise) \times (allowed \ ripple)}{current}, \tag{3.1}$$

where current is the average current flowing through the PDN. Let V_{max} , Z_{max} , and I_{max} denote the maximum magnitude of the worst-case PDN voltage noise v(t), the maximum magnitude of the PDN output impedance $Z(\omega)$, and the maximum magnitude of the time-domain input current i(t), respectively, *i.e.*,

$$V_{max} = \max_{t} |v(t)|, \qquad (3.2)$$

$$Z_{max} = \max_{\omega} |Z(\omega)|, \qquad (3.3)$$

$$I_{max} = \max_{t} |i(t)|. \tag{3.4}$$

The assumption behind Eq. 3.1 is that V_{max} is less than the product of Z_{max}

and I_{max} , *i.e.*, the ratio

$$\gamma = \frac{(power \ supply \ noise) \times (allowed \ ripple)}{Z_{target}(\omega) \times (current)} = \frac{V_{max}}{Z_{max} \times I_{max}}$$
(3.5)

is no more than 1.

Eq. 3.5 is based on Ohm's law. However, since V_{max} and I_{max} are functions of time and Z_{max} is a function of frequency, such assumption does not necessarily hold and the ratio γ may be larger than 1. Thus, the frequency-domain design approach may lead to a PDN design with larger power supply noise than expected value. For example, if $\gamma = 1.5$ and 5% of the allowed supply voltage ripple, the actual maximum noise of the designed PDN is 7.5%, *i.e.*, a 50% more than expected ripple.

Several works have been performed which are related to the time-domain and the frequency-domain response of PDN analysis [37, 34, 36, 19, 26, 60, 24]. Kim *et al.* [37] proposed a design methodology for optimized power distribution networks based on frequency-domain PDN resonance information. His method applies to high (quality factor) LC tank model without equivalent series resistance (ESR) considered. Kim *et al.* [34] gave a closed-form expression for supply noise caused by IC switching current for a PDN structure. Drabkin *et al.* [19] presented a method of generating the worst-case PDN voltage noise based on the superposition of step responses. Ghani and Najm [26] found a vectorless approach to obtain the upper bound of the worst-case noise without any simulation based on given load current constraints. Sun and Smith [60] proposed a method to systematically characterize on-chip PDN noise and generate a worst-case current pattern. However, none of these works provides a quantitative analysis on the relation between the worst-case peak PDN voltage noise and the peak value of its impedance magnitude.

In this chapter, we propose a method to analyze the ratio γ of the maximum time-domain voltage noise and the peak amplitude of the frequency-domain impedance profile. We give the exact upper bound of the ratio in LC tank cases instead of the approximations given by [37, 34, 60]. We prove that for a standard LC tank case in PDN structure, γ is no more than 1.5.

3.2 **Problem Formulation**

In this section, we formulate the problem as to maximize the ratio γ in a general PDN system. The ratio γ is proportional to the worst-case peak voltage noise V_{max} in time domain over the peak impedance Z_{max} in frequency domain. Without loss of generality, the upper bound of load current I_{max} is set to 1 throughout of this chapter. Therefore, the problem formulation can be described as

$$\max \quad \gamma = V_{max}/Z_{max},\tag{3.6}$$

$$s.t. \ 0 \le i(t) \le 1, \ \forall t \ge 1.$$
 (3.7)

In the following section, we analyze the output impedance of system Z(s)in s-domain as Fourier transform is equivalent to Laplace transform $(Z(s) = Z(\omega))$ when $s = j\omega$. Z(s) can be distinguished by two categories: Z(s) without passive realizability constraints and Z(s) with passive realizability constraints, based on the location of poles and zeros of the system. Unless an active voltage regulator module is included, a PDN can be usually modeled as a passive RLC network [34]. We focus on Z(s) with passive realizability in this chapter.

3.2.1 Worst-Case PDN Voltage Noise

The first step to find the maximum ratio γ is to generate the worst-case PDN voltage noise V_{max} . One method to find V_{max} is from the convolution of the impulse responses method. The PDN system Z(s) is characterized by its impulse response h(t) in time domain. Load current i(t) is caused by circuit activities. Therefore, the voltage noise v(t) is written as the convolution of h(t) and i(t), *i.e.*,

$$v(t) = \int_{0}^{\infty} h(\tau)i(t-\tau)d\tau$$
(3.8)

Since i(t) is bounded in Eq. 3.7, the maximum voltage noise, $\max_{t} |v(t)|$, can be generated by setting $i(t - \tau) = 1$ when $h(\tau) \ge 0$ and $i(t - \tau) = 0$ when $h(\tau) < 0$. If we set time t = T is long enough, *i.e.*, $h(t) \approx 0$ when t > T, we can calculate the worst-case noise,

$$V_{max} = \max_{t} |v(T)|. \tag{3.9}$$

Drabkin *et al.* proposed another method of creating the worst-case PDN voltage noise in [19]. This method is based on the superposition of the step responses, corresponding to the worst-case generation method based on impulse response discussed above. Let us assume that the unit step response of a PDN is $v_u(t)$. The idea is to overlay all the local maximums V_{Mi} and local minimums V_{mi} of the step response at the same point. The resultant input pattern is the superposition of many reverse time-shifted step inputs and time-shifted step inputs. The value "1" of the input covers the increasing period of the step response. It can be proved that the method proposed in [19] generates the worst-case output voltage noise.

Lemma 1 Given a linear PDN with step response of $v_u(t)$ and the input current is bounded, i.e., $0 \le i(t) \le 1$, the worst-case PDN voltage noise can be generated by the superposition of step responses,

$$V_{max} = \sum_{i=1}^{N} (V_{Mi} - V_{mi}) + V(\infty), \qquad (3.10)$$

where V_{M1} , V_{M2} , ..., and V_{MN} denote the local maximums of $v_u(t)$; V_{m1} , V_{m2} , ..., and V_{mN} denote the local minimums of $v_u(t)$; and $V(\infty)$ denotes the stabilized IR drop when i(t) = 1.

Proof 1 Lemma 1 can be proved by observing that the input current i(t) is bounded and the impulse response is the derivative of the step response. The local maximums and minimums of the step response correspond to the positive/negative areas of the impulse response.

We can set the impulse response of the system as $h(t) \ge 0$, when $t \in [0, t_1] \cup [t_2, t_3] \cup ... \cup [t_{2n}, t_{2n+1}]...$ and $h(t) \le 0$, when $t \in [t_1, t_2] \cup [t_3, t_4] \cup ... \cup [t_{2n-1}, t_{2n}]...$

Since the step response $v_u(t)$ is the time integral of the impulse response, i.e.,

$$v_u(t) = \int_0^t h(\tau) d\tau, \qquad (3.11)$$

the local maximums/minimums of the step response can be expressed as follows,

$$\begin{cases}
V_{Mi} = \int_{0}^{t_{2i-1}} h(\tau) d\tau \\
V_{mi} = \int_{0}^{t_{2i}} h(\tau) d\tau
\end{cases}, where \ i = 1, 2, ..., n.$$
(3.12)

From Eq. 3.8 and 3.9, the worst-case noise can be found as,

$$V_{max} = \int_{0}^{t_{1}} h(\tau) \times 1 d\tau + \int_{t_{3}}^{t_{2}} h(\tau) \times 1 d\tau + \int_{t_{5}}^{t_{4}} h(\tau) \times 1 d\tau + \dots$$

$$= \int_{0}^{t_{1}} h(\tau) d\tau - \int_{0}^{t_{2}} h(\tau) d\tau + \int_{0}^{t_{3}} h(\tau) d\tau - \int_{0}^{t_{4}} h(\tau) d\tau + \int_{0}^{t_{5}} h(\tau) d\tau - \dots$$

$$= V_{M1} - V_{m1} + V_{M2} - V_{m2} + V_{M3} - \dots$$

$$= \sum_{i=1}^{N} (V_{Mi} - V_{mi}) + V(\infty).$$

(3.13)

When N is sufficiently large, we have $V(\infty) \approx V_{MN} \approx V_{mN}$. Thus, we prove Lemma 1.

3.2.2 Peak Output Impedance

The peak output impedance of PDN Z_{max} is calculated by setting the derivatives of $|Z(\omega)|$ to zero and judge the sign of the second-order derivatives. If multiple anti-resonance peaks exist in the impedance profile, *i.e.*, Z_{peak1} , Z_{peak2} ,..., Z_{peakn} ,

$$Z_{max} = \max(Z_{peak1}, Z_{peak2}, ..., Z_{peakn}).$$
 (3.14)

Plugging Eq. 3.10 and 3.14 into Eq. 3.6, we can find the ratio γ for a given PDN.

3.3 Maximum Ratio γ in Series RL/RC Circuits and Standard LC Tanks

In this section, we discuss the maximum ratio γ of two basic PDN models. The transfer function of the PDN models is passive realizable function as an impedance if and only if it is a rational positive real function of s. A function of Z(s) is positive real (p.r.) if the following conditions are satisfied [44]:

- Z(s) is real for real s and is a ratio of polynomials in s.
- $Re[Z(s)] \ge 0$ for all positive real s.

• All the poles and zeros of Z(s) are in the left half plane, with any poles on the imaginary axis being simple and having positive residues.

Two PDN models listed below are addressed in this section, which are the critical components for PDN designs. One is series RL/RC circuit, and the other is standard LC tank.

3.3.1 Series RL/RC Circuit

Series RL/RC circuit can be modelled as a first-order impedance function. In this subsection, we show the upper bound of γ for the first-order impedance function.

Theorem 1 For a first-order system function Z(s) of a passive network, γ is always 1.

Proof 2

$$Z(s) = \frac{k}{s-p},\tag{3.15}$$

or

$$Z(s) = \frac{s-z}{s-p},$$
(3.16)

where k is a constant, z and p are the zero and the pole of the system respectively. To satisfy the realizability constraints, $k \ge 0$, $z \le 0$ and $p \le 0$.

(a) For Z(s) expressed by Eq. 3.15, the magnitude of Z(s) as a function of

 ω can be written as

$$|Z(\omega)| = k\sqrt{\frac{1}{\omega^2 + p^2}}.$$
 (3.17)

Its step response is represented as

$$v_u(t) = -\frac{k}{p}(1 - e^{pt})u(t).$$
(3.18)

From Eq. 3.17 and 3.18, since we observe that $v_u(t)$ increases with t increasing and $|Z(\omega)|$ decreases with ω increasing. Therefore,

$$V_{max} = Z_{max} = -\frac{k}{p}.$$
(3.19)

(b) For Z(s) from Eq. 3.16, the magnitude of Z(s) with frequency can be expressed as follows,

$$|Z(\omega)| = \sqrt{1 + \frac{z^2 - p^2}{\omega^2 + p^2}}.$$
(3.20)

and its step response is

$$v_u(t) = \left[\frac{z}{p} + (1 - \frac{z}{p})e^{pt}\right]u(t), \qquad (3.21)$$

where u(t) is the unit step response. Similarly, $|Z(\omega)|$ and $v_u(t)$ monotonically decreases and increases as ω or t increases respectively. We have $V_{max} = Z_{max} = max(1, \frac{z}{p})$.

In summary, $V_{max} = Z_{max}$ for both Z(s) cases. Thus, the ratio γ of the first-order impedance function is

$$\gamma = 1. \tag{3.22}$$



Figure 3.1: Standard LC tank with ESR_c

3.3.2 Standard LC Tank with ESR_c

In this subsection, the maximum ratio γ for the standard LC tanks with ESR_c in real-case PDN structures is analyzed. In addition, we extend the study to two special LC tank cases. Fig. 3.1 shows a standard LC tank with ESR_c . R_1 and L are to model the parasitic resistance and inductance of the PDN interconnects. C is to model the decoupling capacitors. A resistor R_2 is placed in series with C to consider the effect of ESR_c . The output impedance of the LC tank with ESR_c can be written as

$$Z(s) = \frac{s^2 L C R_2 + s(R_1 R_2 C + L) + R_1}{s^2 L C + S(R_1 + R_2)C + 1}.$$
(3.23)

The quality factor Q is expressed as

$$Q = \frac{1}{R_1 + R_2} \sqrt{\frac{L}{C}}.$$
 (3.24)

The natural frequency is defined as

$$\omega_0 = 1/\sqrt{LC}.\tag{3.25}$$

Z(s) can be rewritten to

$$Z(s) = \frac{R_2(s + \frac{\omega_0}{Q_1})(s + \omega_0 Q_2)}{s^2 + \frac{\omega_0}{Q}s + \omega^2},$$
(3.26)

where $Q_1 = \frac{1}{R_1} \sqrt{\frac{L}{C}}$, $Q_2 = \frac{1}{R_2} \sqrt{\frac{L}{C}}$. The maximum ratio γ for the standard LC tank case is given in Theorem 2.

Theorem 2 For the standard LC tank as shown in Fig. 3.1, the maximum ratio γ is 1.5.

Theorem 2 can be further described as Lemma 2 and Lemma 3 upon the sign of the discriminant Δ of the denominator of Z(s) (or equivalently, the value of the quality factor Q).

Lemma 2 For the overdamped or critically damped LC tank ($Q \le 0.5$) as shown in Fig. 3.1, the maximum ratio γ is 1.5.

Lemma 3 For the underdamped LC tank (Q > 0.5) as shown in Fig. 3.1, the maximum ratio γ is 1.05.

Proof 3 According to the discriminant Δ of the denominator of Z(s), we divide the problem into two cases, i.e. $\Delta \geq 0$ or $\Delta < 0$.

i) When $\Delta \geq 0$ ($Q \leq 0.5$), all zeros and poles are real numbers and the LC tank is overdamped or critically-damped. From the relative locations of zeros and poles in the left half plane, we can conclude that

$$Z_{max} = max(R_1, R_2). (3.27)$$

To calculate V_{max} , we first derive the step response $v_u(t)$ from inverse Laplace transform of $\frac{Z(s)}{s}$. By using partial fraction expansion method, we find $v_u(t)$,

$$v_u(t) = k_1 + k_2 e^{p_1 t} + k_3 e^{p_2 t}, (3.28)$$

where

$$\begin{cases} k_1 = R_1, \\ k_2 = R_2 \frac{-\frac{1}{2} + \frac{1}{2}\sqrt{1 - 4Q^2} + \frac{Q}{Q_1} + QQ_2 + \frac{R_1}{R_2}(-\frac{1}{2} - \frac{1}{2}\sqrt{1 - 4Q^2})}{\sqrt{1 - 4Q^2}}, \\ k_2 = R_2 \frac{-\frac{1}{2} - \frac{1}{2}\sqrt{1 - 4Q^2} + \frac{Q}{Q_1} + QQ_2 + \frac{R_1}{R_2}(-\frac{1}{2} + \frac{1}{2}\sqrt{1 - 4Q^2})}{-\sqrt{1 - 4Q^2}}, \end{cases}$$
(3.29)

and

$$\begin{cases} p_1 + p_2 = -\frac{\omega_0}{Q}, \\ p_1 p_2 = \omega_0^2. \end{cases}$$
(3.30)

From the relative locations of zeros and poles, there is a local minimum for the step response $v_u(t)$. The local minimum monotonically decreases as Q decreases. When $Q \to 0$, we observe the smallest local minimum. Since we focus on the maximum ratio γ_{max} , we simplify Eq. 3.29 by setting $Q \to 0$,

$$\begin{cases} k_1 = R_1, \\ k_2 = -\frac{R_1^2}{R_1 + R_2}, \\ k_3 = \frac{R_2^2}{R_1 + R_2}. \end{cases}$$
(3.31)

We define t_0 as the time when local minimum v_{min} of $v_u(t)$ occurs, which

can be solved by setting the derivative of $v_u(t)$ to be zero. Thus,

$$t_0 = \frac{1}{p_1 - p_2} ln \left[\frac{(p_2 - z_1)(p_2 - z_2)}{(p_1 - z_1)(p_1 - z_2)} \right].$$
(3.32)

When $Q \rightarrow 0$, we substitute Eq. 3.31 and 3.32 into Eq. 3.28 and have

$$v_{\min_{Q\to 0}} = \frac{R_1 R_2}{R_1 + R_2},\tag{3.33}$$

and

$$v_{\min_{Q\to 0}} < v_{\min_{Q\neq 0}}.\tag{3.34}$$

From Eq. 3.28-3.34, we notice that the worst-case noise V_{max} occurs at $Q \rightarrow 0$,

$$v_{max_{Q\to 0}} = v_u(0) - v_{min_{Q\to 0}} + v_u(\infty) \ge v_u(0) - v_{min_{Q\neq 0}} + v_u(\infty) = V_{max_{Q\neq 0}}.$$
 (3.35)

where $v_u(0) = R_2$, $v_u(\infty) = R_1$. Thus, we have

$$V_{max} = R_1 + R_2 - \frac{R_1 R_2}{R_1 + R_2}.$$
(3.36)

Combining Eq. 3.27 and 3.36, the ratio γ is

$$\gamma = \frac{V_{max}}{Z_{max}} = \frac{R_1 + R_2 - \frac{R_1 R_2}{R_1 + R_2}}{max(R_1, R_2)}.$$
(3.37)

Since Eq. 3.37 is symmetric in terms of R_1 and R_2 , we hereby assume $R_1 \ge R_2$. Thus, Eq. 3.37 can be expressed as

$$\gamma = 1 + \frac{1}{\psi + \psi^2}, \text{ while we define } \psi = \frac{R_1}{R_2} \ge 1.$$
 (3.38)

Therefore, we have the maximum ratio

$$\gamma_{max} = 1.5, \text{ when } R_1 = R_2 \text{ and } Q \to 0.$$
 (3.39)

ii) When $\Delta < 0$ (Q > 0.5), the poles are complex numbers and the LC tank is underdamped. $v_u(t)$ of an underdamped LC tank can be expressed as follows,

$$v_u(t) = K_1 + e^{-\alpha t} (K_2 e^{\beta t} + K_2^* e^{-\beta t}), \qquad (3.40)$$

or

$$v_u(t) = K_1 + 2e^{-\alpha t} [A\cos\beta t - B\sin\beta t], \qquad (3.41)$$

where

$$\begin{cases} \alpha = \frac{\omega_0}{2Q}, \\ \beta = \sqrt{\omega_0^2 - (\frac{\omega_0}{2Q})^2}, \\ K_1 = sH(s)|_{s=0} = \frac{R_2 * \frac{\omega_0}{Q_1} * \omega_0 Q_2}{\omega_0^2} = R_1, \\ K_2 = (s + \alpha - j\beta)H(s)|_{s=-\alpha+j\beta} = \frac{R_2(\alpha + j\beta + \frac{\omega_0}{Q_1})(-\alpha + j\beta + \omega_0 Q_2)}{(-\alpha + j\beta) * 2j\beta}, \\ K_2 = A + j * B, \\ K_2 = A - j * B. \end{cases}$$
(3.42)

After simplifying the results, we have

$$A = \frac{R_2}{2} \left(1 - \frac{R_1}{R_2}\right) = \frac{1}{2} (R_2 - R_1), \qquad (3.43)$$

$$B = R_2 \frac{\frac{1}{2Q} \left(1 + \frac{Q_2}{Q_1}\right) - \left(Q_2 + \frac{1}{Q_1}\right)}{2\sqrt{1 - \frac{1}{4Q^2}}}.$$
(3.44)



Figure 3.2: The step response of an underdamped LC tank with ESR_c (Q > 0.5). (a) The first local extremum is a peak. (b) The first local extremum is a valley.

By equating the derivative of Eq. 3.41 to zero, we calculate the time t_k where local extrema of $v_u(t)$ occur,

$$t_{k} = \begin{cases} \frac{1}{\beta} (\arctan \frac{\beta B + A\alpha}{B\alpha - A\beta} + k\pi), \ k = 0, 1, \dots, : \frac{\beta B + A\alpha}{B\alpha - A\beta} \ge 0, \\ \frac{1}{\beta} (\arctan \frac{\beta B + A\alpha}{B\alpha - A\beta} + k\pi), \ k = 1, 2, \dots, : \frac{\beta B + A\alpha}{B\alpha - A\beta} < 0, \end{cases}$$
(3.45)

where $\frac{\beta B+A\alpha}{B\alpha-A\beta} = \frac{(Q_2-\frac{1}{Q_2})\sqrt{1-\frac{1}{4Q^2}}}{\frac{1}{2Q_2}+\frac{1}{2QQ_2}-2}$. By plugging back into Eq. 3.41, the local extrema v_{ek} of $v_u(t)$ are

$$v_{ek} = R_1 + 2e^{-\frac{\omega_0}{2Q}t_k} \left[\frac{R_2 - R_1}{2}\cos\beta t_k - R_2\frac{\frac{1}{2Q}(1 + \frac{Q_2}{Q_1}) - (Q_2 - \frac{1}{Q_1})}{2\sqrt{1 - \frac{1}{4Q^2}}}\sin\beta t_k\right].$$
 (3.46)

From Eq. 3.46, the voltage peaks and valleys of the step response can be expressed as

$$PEAKs: V_{Mi} = v_{ek}, when v_{ek} > R_1,$$
 (3.47)

$$VALLEYs: V_{mi} = v_{ek}, when v_{ek} < R_1.$$

$$(3.48)$$

Based on the sequences of voltage peaks and valleys in time-domain, V_{max}

is determined from the following two cases.

a. The first extremum is a local maximum as shown in Fig. 3.2(a). In this case, V_{max} can be obtained from Eq. 3.10,

$$V_{max} = \sum V_{Mi} - \sum V_{mi} + v_u(\infty).$$
 (3.49)

b. The first extremum is a local minimum as shown in Fig. 3.2(b). In this case, V_{max} can be obtained from the following expressions.

$$V_{max} = v_u(0) + \sum V_{Mi} - \sum V_{mi} + v_u(\infty).$$
(3.50)

Eq. 3.50 still satisfies Eq. 3.10, as $v_u(0)$ can be considered as one local maximum V_{Mi} .

 Z_{max} is calculated by solving $\frac{|Z(\omega)|}{d\omega} = 0$. We hereby define $y = (\frac{\omega}{\omega_0})^2$ and Eq. 3.26 is changed to,

$$|Z(\omega)|^{2} = |Z(y)|^{2} = \frac{y^{2} \frac{Q_{1}^{2}}{Q_{2}^{2}} + y(Q_{1}^{2} + \frac{1}{Q_{2}^{2}} + 1)}{y^{2} + y((\frac{1}{Q_{1}} + \frac{1}{Q_{2}})^{2} - 2) + 1}.$$
(3.51)

We set $y = y_0$ as the solution of $\frac{d|Z(y)|}{dy} = 0$, So y_0 can be expressed as,

$$y_0 = \frac{\sigma_1 + Q_1^2 Q_2^4 - Q_1^4 Q_2^2 - Q_1 Q_2 \sigma_1}{-Q_1^4 Q_2^4 - 2Q_1^4 Q_2^2 + Q_1^4 + 2Q_1^3 Q_2^4},$$
(3.52)

where $\sigma_1 = \sqrt{Q_1^6 Q_2^6 + 2Q_1^6 Q_2^4 + 2Q_1^5 Q_2^5 + 2Q_1^5 Q_2^3 + 2Q_1^4 Q_2^6 + 5Q_1^4 Q_2^4 + 2Q_1^3 Q_2^5}$. Apparently, y is non-negative value from its definition. However, y_0 is not always positive in Eq. 3.52. Therefore, the peak impedance can be analyzed into two cases upon the sign of y_0 .

When $y_0 \geq 0$, there is an extremum in the frequency domain, where Z_{max}



Figure 3.3: Impedance magnitude sweep of an underdamped LC tank with ESR_c , when $y_0 > 0$. The peak occurs at $Z_{max} = |Z(y_0)|$.



Figure 3.4: Impedance magnitude sweep of an underdamped LC tank with ESR_c , when $y_0 < 0$. (a) $Z_{max} = Z(0)$, (b) $Z_{max} = Z(\infty)$.

is

$$Z_{max} = |Z(y_0)|. (3.53)$$

Fig. 3.3 shows the impedance magnitude sweep when $y_0 \ge 0$.

When $y_0 < 0$, Z_{max} monotonically increases or decreases in the frequency domain. Therefore, we have

$$Z_{max} = max(Z(0), Z(\infty)). \tag{3.54}$$

Fig. 3.4 shows the impedance magnitude sweep when $y_0 < 0$.

Combining the above analyses on different cases of V_{max} and Z_{max} , the bound of γ for an underdamped LC tank is summarized in Fig. 3.8 as

$$\frac{2}{\pi} < \gamma \le 1.05.$$
 (3.55)

The underdamped LC tank is particularly of interest as it is commonly observed in industrial PDN designs. Fig. 3.5 shows the bound of γ as contour lines. It can be inferred that $Q_2 > Q > 0.5$ from their definitions. We observe that



Figure 3.5: The contour line (γ) as a function of Q and Q_2 (The shaded area is not a valid area due to the condition $Q_2 > Q > 0.5$.)

 $\gamma_{max} \approx 1.05$ when Q = 0.66 and $Q_2 = 0.67$. When $Q \to \infty, \gamma \to 2/\pi$.

We further analyze the analytical solution of V_{max} , Z_{max} and γ under two special LC tank cases such as (1) $R_1 = R_2$ and (2) $R_2 = 0$.

(1) When $R_1 = R_2 = R$, the expressions of Z_{max} and V_{max} are listed below.

$$Z_{max} = \begin{cases} R & : Q \le 0.5, \\ RQ(\frac{1}{2Q} + 2Q) & : Q > 0.5, \end{cases}$$
(3.56)

and

$$V_{max} = \begin{cases} R + R\sqrt{\frac{1}{4Q^2} - 1}e^{-\frac{1}{\sqrt{1 - 4Q^2}}ln(\frac{1}{2Q} + \sqrt{\frac{1}{4Q^2 - 1}})} & : Q < 0.5, \\ R & : Q = 0.5, \\ R + R(2Q - \frac{1}{2Q})\frac{e^{-\frac{1}{\sqrt{4Q^2 - 1}}arctan(\sqrt{4Q^2 - 1})}}{1 - e^{-\frac{\pi}{\sqrt{4Q^2 - 1}}}} & : Q > 0.5. \end{cases}$$
(3.57)

The ratio γ from the results of Eq. 3.56 and 3.57 is shown in Fig. 3.6. We



Figure 3.6: The ratio γ versus the quality factor Q (when $R_1 = R_2$)

notice that when Q = 0.5 and $R_1 = R_2 = \sqrt{L/C} = R$, Z_{max} is flat throughout the frequency domain and the voltage step response is a constant. Such LC tank is called as a distortion-less system, and γ is always one regardless of the input current pattern.

2) When $R_2 = 0$, the LC tank is simplified to a three-element circuit as shown in Fig. 3.7.

The impedance profile of Fig. 3.7 can be determined from

$$Z(s) = \frac{sL + R}{s^2 LC + sRC + 1}.$$
(3.58)

The expressions of Z_{max} and V_{max} of this LC tank case are listed below, where



Figure 3.7: Standard LC tank without ESR_C .

$$Q = Q_1 \text{ as } Q_2 \to \infty,$$

$$Z_{max} = \begin{cases} R & : \ Q \le 0.6436, \\ RQ^2 \sqrt{\frac{1}{2Q\sqrt{Q^2 + 2} - 2Q^2 - 1}} & : \ Q > 0.6436, \end{cases}$$
(3.59)

and

$$V_{max} = \begin{cases} R & : Q \le 0.5, \\ R(1+Q\frac{e^{\frac{\pi - arctan\sqrt{4Q^2 - 1}}{\sqrt{4Q^2 - 1}}}}{1 - e^{-\frac{\pi}{\sqrt{4Q^2 - 1}}}}) & : Q > 0.5. \end{cases}$$
(3.60)

Therefore,

$$\gamma = \begin{cases} 1 & : Q \leq 0.5, \\ 1 + Q \frac{e^{\frac{\pi - arctan\sqrt{4Q^2 - 1}}{\sqrt{4Q^2 - 1}}}}{1 - e^{-\frac{\pi}{\sqrt{4Q^2 - 1}}}} & : 0.5 < Q \leq 0.6436, \\ \frac{1 - e^{-\frac{\pi}{\sqrt{4Q^2 - 1}}}}{1 + Q \frac{e^{\frac{\pi - arctan\sqrt{4Q^2 - 1}}{\sqrt{4Q^2 - 1}}}}{1 - e^{-\frac{\pi}{\sqrt{4Q^2 - 1}}}} & : Q > 0.6436. \end{cases}$$
(3.61)

The curve of γ as a function of Q is shown in Fig. 3.8. We observe that the maximum ratio $\gamma \approx 1.041$, when Q = 0.687 for this special case.



Figure 3.8: The ratio γ versus the quality factor Q of a LC tank without ESR_C .

3.4 Case Study: A Complete Power Distribution Network Path

In this section, we analyze V_{max} and Z_{max} of a complete PDN path case, which includes VRM, board, package, on-chip power distribution, and decoupling capacitors (Fig. 3.9) [29]. The on-chip power grid model is lumped with the package model as a single port. The circuit model is extracted from a real PDN design by Sigrity PowerSI 16.61.

Our PDN model includes the output impedance of the VRM and the impedance of the current path from the VRM to bulk decaps (on-board), the impedance of the current path from bulk decaps to the on-package decaps, the impedance of the current path from on-package decaps to die and the on-chip



Figure 3.9: A complete PDN path is illustrated by a lumped cascaded LC tank model. A high order multi-stage PDN system can be approximate to three second-order LC tanks under different frequency regions.



Figure 3.10: The output impedance of a complete PDN path (a) Magnitude (b) Phase.

power grid. We consider the ESR_c and equivalent series inductance (ESL_c) effect for bulk decaps and on-package decaps. For on-die decaps and their associated ESR_c , we include both the intrinsic capacitance of the non-switching transistors in a circuit and the dedicated decoupling capacitance. The ESL_c of on-die decaps is negligible and not considered as the target frequency range of PDN is less than 10GHz. The switching of the load circuit is represented by the current source i(t). The impedance between the on-die decap and the load current is ignored assuming that the decap is placed sufficiently close to the load circuit. The PDN noise is observed at the on-die current load node.

The output impedance of the PDN is shown in Fig. 3.10. There are mainly three anti-resonance peaks around 219.0kHz, 4.372MHz and 91.38MHz in the impedance profile. The peak impedance is shown as,

$$Z_{max} = 0.215(\Omega). (3.62)$$

Those anti-resonance peaks result in low-frequency, middle-frequency and highfrequency fluctuations in the PDN step response. By catching the maximums and minimums of the step response and applying Eq. 3.10 in Matlab, the worst-case voltage noise is calculated as

$$V_{max} = 0.2998(V). \tag{3.63}$$

Thus, the maximum γ for this PDN case is

$$\gamma_{max} = 1.394.$$
 (3.64)

Therefore, for real PDN cases, the maximum γ can be greater than 1, which

shows that the traditional target impedance method underestimates the worst-case noise by assuming γ no more than 1.

Fig. 3.11 demonstrates the method of generating the worst-case voltage noise in time domain. Load current is bounded from 0 to 1(A). Based on the impedance profile in Fig. 3.10, the impulse response h(t) of the system is determined. We then apply the convolution method in Section 3.2 to figure out the worst-case voltage noise and the load current pattern. The simulation time step is set to 10ps and T in Eq. 3.9 is set to 0.1ms. The worst-case voltage noise of the PDN is shown in Fig. 3.11(a), and its corresponding input current pattern is shown in Fig. 3.11(b). Fig. 3.11(c) shows zoom-in view at the peak voltage noise at T = 0.1ms with the high-frequency switching current pattern.

Another way to quickly estimate the worst-case voltage noise is from the standard LC tank discussed in Section 3.3.2. As shown in Fig. 3.9, a three-stage PDN model is decomposed into three LC tank models in different frequency regions. Each tank contributes to a portion of the worst-case noise which can be calculated from Eq. 3.46 - 3.50. We also observe that there is a noise cancellation effect between two neighboring tanks, which means that the sum of voltage noises from all three tanks exceeds the actual worst-case noise from Eq. 3.10. The amount of noise cancellation can be estimated by the impedance valley between two peaks. For example, Z_{valley_1} between peak m1 (Tank A) and m2 (Tank B) is $15.5m\Omega$, Z_{valley_2} between peak m2 and m3 (Tank C) is $10.8m\Omega$. Thus, the estimated worst-case noise cancel as,

$$\widetilde{V}_{max} = V_{tank_A} + V_{tank_B} + V_{tank_C} - I_{max} \times (Z_{valley_1} + Z_{valley_2}), \qquad (3.65)$$

where V_{tank_A} is the peak noise from Tank A, etc. $I_{max} = 1(A)$ from Eq. 3.7.



Figure 3.11: (a) Worst-case peak noise of a complete PDN path, (b) Worst-case load current pattern, (c) The zoomed-in view for the worst peak noise on PDN. (d) The zoomed-in view for the worst-case load current pattern.

We list the noise contribution of each tank of Fig. 3.11(a)-(c) to the worstcase noise in the first case of Table 1. V_{tank_A} , V_{tank_B} and V_{tank_C} are the worstcase noise of the three standard LC tanks decomposed from the complete PDN path. Z_{valley_1} and Z_{valley_2} are extracted from the output impedance profile. \tilde{V}_{max} is the estimated worst-case noise upper bound from Eq. 3.65. The prediction error compared with the exact results V_{max} in Eq. 3.10 is listed in the last column. Compared to the exact result from Eq. 3.63, the estimated result from three LC tank models has an estimation error of 6.80%, which provides designer quick design guidelines to optimize the noise from each LC tank. The method provides quicker prediction than the Eq. 3.10 method in Lemma 1 when a PDN system contains more than two tanks and the impedance peaks are from 100Hz to 10GHz, requiring a small time step with a long time series for simulation, which results in a memoryhungry and time-consuming calculation. By decomposing cascaded LC tank into several standard LC tanks in the frequency-domain, the worst-case noise time can be greatly reduced.

	error $(\%)$	6.80%	3.08%	11.26%
	$V_{max} (V)$	0.2998	0.2597	0.3927
PDN cases.	$\widetilde{V}_{max}\left(V ight)$	0.3202	0.2677	0.4369
ree complete I	Z_{valley_2} (Ω)	0.0108	0.0060	0.0050
rediction of th	Z_{valley_1} (Ω)	0.0155	0.0093	0.0041
st-case noise p	$V_{tank_C}(V)$	0.1437	0.1717	0.1468
3.1 : The wors	$V_{tank_B}(V)$	0.1350	0.0568	0.1447
Table	$V_{tank_A}\left(V\right)$	0.0678	0.0545	0.1545
	Cases	I (Fig. 3.9)	II (Fig. 3.12(a))	III (Fig. 3.12(b))

cases
PDN
complete
f three
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worst-case
The
3.1:
Table

Two extra PDN cases are analyzed to check the accuracy of our proposed prediction method. The circuit models of those two cases are shown in Fig. 3.12(a) and (b). The impedance profiles of the three test cases are diversified in shape in order to test the robustness of our method. Meanwhile, we exclude the case where one tank has the dominant anti-resonance peak in the impedance profile, which resembles to a standard LC tank. For those cases, the estimation error is very small. On average, the estimation error of V_{max} for three cases is 7%.

3.5 Case Study: Power Distribution Network Design Optimization with On-Die Voltage Dependent Leakage Path

3.5.1 Voltage Dependent Leakage Resistance Model

On-die leakage current comes from three main contributors: subthreshold leakage, gate leakage and band-to-band leakage (BTBT) [50]. Gate leakage has been substantially reduced as the high-k dielectrics in massive CMOS production and band-to-band leakage is relatively small compared to the other two. Therefore, we focus on subthreshold leakage in this section.

Subthreshold leakage is a weak inversion current between source and drain in a MOS transistor when the gate voltage is below the threshold voltage V_t . In digital design, we can analyze the subthreshold leakage by setting the gate voltage $V_g = Gnd$ for NMOS and $V_g = V_{dd}$ for PMOS. The weak inversion current I_{ds} is a function of the threshold voltage V_t . V_t is mainly determined by two factors.

• Body effect: $V_t = V_{t0} + \gamma(\sqrt{\phi_s + V_{sb}} - \sqrt{\phi_s}) \approx V_{t0} + k_{\gamma}V_{sb}$, where $\phi_s = 2v_T ln \frac{N_A}{n_i}$, $\gamma = \frac{t_{ox}}{\varepsilon_{ox}} \sqrt{2q\varepsilon_{si}N_A} = \frac{\sqrt{2q\varepsilon_{si}N_A}}{C_{ox}}$ and $k_{\gamma} = \frac{\gamma}{2\sqrt{\phi_s}}$.



Figure 3.12: Two PDN cases to test the proposed prediction method.

• Drain-induced barrier lowering (DIBL): $V_t = V_{t0} - \eta V_{ds}$, where η is on the order of 0.1.

Therefore, the subthreshold leakage can be expressed as,

$$I_{ds} = I_{ds0} e^{\frac{V_{gs} - V_t}{nv_T}} (1 - e^{-\frac{V_{ds}}{v_T}}), \qquad (3.66)$$

where $I_{ds0} = \beta v_T^2 e^{1.8}$, $n = 1.3 \sim 1.7$, $v_T = \frac{kq}{T}$, $V_t = V_{t0} + k_{\gamma} V_{sb} - \eta V_{ds}$ and $\beta = \mu_0 \frac{\varepsilon_{ox}}{T_{ox}} \frac{W}{L}$. (All the parameters are explained in [68].) By setting $V_{ds} = V_{dd}$, it can be inferred that I_{ds} is superlinear proportional to the supply voltage.

The leakage resistance R_{leak} becomes a function of V_{dd} ,

$$R_{leak} = \frac{V_{dd}}{I_{ds}}.$$
(3.67)

We compare the theoretical model from Eq. 3.66 with an industrial 28nm HPm NMOS Spice model. We set the voltage of each port of NMOS: $V_d = V_{dd}$, $V_s = Gnd$, $V_g = Gnd$ and $V_b = Gnd$. The nominal V_{dd} is 0.9V and the operating temperature is set to 25 deg C. The results are shown in Figure 3.13. As the supply voltage is swept from 0.1V to 1.3V, we observe that R_{leak} first increases when $V_{dd} < V_t$, reaches a peak value when $V_{dd} \approx V_t$ and then decreases when $V_{dd} > V_t$. Results show that the theoretical model from Eq. 3.66 can accurately match the industrial model when $V_{dd} > 0.5V$.

Figure 3.13(b) shows that the leakage resistance of a single transistor is on the order of $10^7\Omega$. Meanwhile, the transistor count of a single high performance CPU had topped 5 billion in 2012 [4]. Suppose 10% of transistors contribute to the on-die leakage, the equivalent full-chip leakage resistance can be found on the order of $100m\Omega$. Since $18m\Omega$ target impedance for a 1GHz chip with $1cm^2$ die area in 2012 (Figure 1.1), the ratio of leakage resistance over target impedance can be approximate to five. To cover all the possible leakage resistance ratio in a wide range (from 1 to 100) in this section.

3.5.2 RLC Tank Model with Leakage Resistance

We discuss the impact of leakage resistance on PDN noise of the RLC tank model in this subsection. Figure 3.14 shows a complete PDN path for systemlevel analysis. Previous studies show that RLC tank model is a basic element of PDN and the worst-case noise is a summation of the worst-case noise from each individual tank [73]. Traditionally, the on-chip load is modelled as a current source (Figure 3.14(a)). Here we model the on-chip load as a current source in parallel with a constant leakage resistor R_{leak} (Figure 3.14(b)) or a current source in parallel



Figure 3.13: (a) Leakage current vs supply voltage (b) Equivalent leakage resistance vs supply voltage



Figure 3.14: A circuit diagram characterizes the impedance of PDN. On-chip load can be modelled as (a) a single current source, (b) a current source with constant leakage resistor, (c) a current source with voltage-dependent leakage resistor.



Figure 3.15: A RLC tank model with leakage resistance

with a voltage-dependent leakage resistor $R_{leak}(v(t))$ (Figure 3.14(c)).

Figure 3.15 shows a RLC tank model with leakage resistance R_3 . Its impedance profile Z(s) in Laplace domain can be expressed as,

$$Z(s) = \frac{s^2 L C R_2 + s(R_1 R_2 C + L) + R_1}{s^2 L C + s(R_1 + R_2)C + 1} / R_3(s)$$

= $\frac{(s^2 L C R_2 + s(R_1 R_2 C + L) + R_1)R_3(s)}{s^2 L C + s(R_1 + R_2)C + 1 + R_3(s)}.$ (3.68)

The PDN noise v(t) is calculated from the convolution of the load current i(t) and the system impulse responses h(t),

$$v(t) = \int_{0}^{\infty} h(\tau)i(t-\tau)d\tau$$

$$\forall t: 0 \le i(t) \le a$$
(3.69)

where h(t) is from the inverse Laplace transform of Z(s). Numerically, the worstcase noise (voltage droop) V_{max} can be obtained by setting $i(t - \tau) = a$ when $h(\tau) > 0$ and $i(t - \tau) = 0$ when $h(\tau) \le 0$. We analyze the problem by setting R_3 as a constant value or a voltage-dependent variable. The design objective is to minimize the worst-case noise. We also define the overshoot of a PDN to be min(v(t)).

Constant Leakage Resistance

If R_3 is set to a constant, Eq. 3.68 is simplified to a second-order system. When the leakage resistance is much greater than the impedance of the rest circuit (e.g. two order of magnitude difference), the leakage path can be ignored and the worst-case noise can be predicted from [73]. Otherwise, the leakage path needs to be included in the worst-case noise calculations.

For example, we extract a RLC tank with $(C = 0.1\mu F, L = 0.1nH)$ from a PDN. The upper bound of i(t) is set to 1. From various combinations of R_1 and R_2 , we search for the minimum worst-case noise from Eq. 3.69 in Matlab. Simulation results show that the minimum value of the worst-case noise is 0.0282V, where the $R_1 = 0.018\Omega$ and $R_2 = 0.022\Omega$. The peak impedance is $35.1m\Omega$ without leakage resistance R_3 . Based on this peak impedance range, we sweep the corresponding R_3 from 30Ω to $30m\Omega$. As R_3 decreases, we find the worst-case noise monotonically drops as well. When R_3 falls in the same magnitude of the original target impedance without R_3 , R_2 gradually decreases and R_1 drops dramatically for the minimal worst-case noise. Our observation of the minimum value of the worst-case noise and its corresponding optimal R_1 and R_2 are shown in Figure 3.16.

Voltage-Dependent Leakage Resistance

 R_3 is modelled as a function of the voltage at the load $(V_{dd} - v(t))$ (Eq. 3.67) in this subsection. The nominal voltage V_{dd} is set to 0.9V and the tolerance of supply noise is set to $\pm 10\%$ of V_{dd} . We keep the same parameters as the previous case: $C = 0.1\mu F$, L = 0.1nH, $R_1 = 0.018\Omega$, $R_2 = 0.022\Omega$ and increase the upper


Figure 3.16: (a) The optimal value R_1 and R_2 (with minimum worst-case noise) as leakage R_3 decreases. (b) The minimum worst-case noise of a RLC tank as leakage R_3 decreases.

bound of i(t) to 3.17A to scale up the noise to $V_{noise} = 0.09V$.

Eq. 3.8 cannot be directly applied to calculate v(t) in this case as the impulse response of the system h(t) changes dynamically due to the variations from the leakage resistance. Instead, we use the Backward Euler method to analyze this model. We set inductor current $i_L(t)$ and capacitor voltage $v_C(t)$ as two variables and derive two equations from Figure 3.15. R_3 is updated in each time step according the current supply voltage level.

$$\begin{cases} L\frac{di_L}{dt} + i_L R_1 = v_C + C\frac{dv_C}{dt}R_2\\ i_L + C\frac{dv_C}{dt} + \frac{1}{R_3(t)}(L\frac{di_L}{dt} + i_L R_1) = i(t) \end{cases}$$
(3.70)

Figure 3.17 shows how leakage resistance R_3 changes in real-time as the load current i(t) changes. Assume $R_3 = 300m\Omega$ at nominal voltage $V_{dd} = 0.9V$.

We compare the PDN noise with same load current pattern for both constant leakage resistance model and voltage-dependent leakage resistance model.



Figure 3.17: Leakage resistance R_3 as the load current i(t) changes.

We set R_3 at the nominal voltage equal across all the models.

Our results are shown in Figure 3.18. Voltage noise is divided into two categories: overshoot and droop. Results show that the constant R_3 model underestimates voltage droop/overshoot for more than 16% compared to voltage-dependent model when R_3 approaches the impedance of the rest circuit without R_3 .

We also observe that when R_3 is set to the value at $V_{dd} - I_{avg} * DCR$ in the constant leakage model, where I_{avg} is the average load current and DCR is DC resistance of PDN, it provides similar noise value as the voltage dependent model. It slightly underestimates the droop and overestimate the overshoot (both differences are less than 2%). This approximation method can greatly reduce the simulation time since there is no need to update R_3 in Eq. 3.70 for each time step.

3.5.3 A Complete PDN Path with On-Die Leakage

A complete PDN path with on-die leakage is set up from Figure 3.14(c). Its impedance profile is shown in Figure 3.19 with different leakage resistors. As the



Figure 3.18: Voltage noise of a RLC tank with different leakage resistance models

leakage resistance R_3 drops, the magnitude of all the impedance peaks is reduced.

Suppose that R_3 is $300m\Omega$, we compare the results of the voltage noise between the constant and voltage-dependent leakage models in time-domain in Figure 3.20. The constant leakage model at V_{dd} underestimates the peak voltage noise 5% compared to the voltage-dependent leakage resistance model. Figure 3.21 shows the voltage noise (droop and overshoot) with different leakage resistance models from Figure 3.19. The constant leakage at V_{dd} model underestimates the maximum voltage droop(overshoot) for up to 16% (25%) compared to voltagedependent model, while the constant leakage at $V_{dd} - I_{avg} * DCR$ model underestimates the droop for only 2% and overestimates the overshoot up to 3%.

3.6 Summary

In this chapter, we define the ratio of the worst-case voltage noise and the maximum impedance of PDNs. We analyze LC tank models in real PDN



Figure 3.19: Impedance profile of a complete PDN path with various leakage resistance values.



Figure 3.20: The peak voltage noise (droop) of a complete PDN path in time-domain



Figure 3.21: Voltage noise of a complete PDN path with different leakage resistance models

structures. The maximum ratio γ for LC tank is proved to be 1.5 when the resistors $R_1 = R_2$ and the quality factor $Q \to 0$. We analyze the worst-case noise of a complete PDN path and demonstrate that γ is more than 1. In addition, we propose a method to estimate the worst-case noise of a complete PDN path through the analytical solution of several LC tanks. Our results contradict the assumption of the well-known "target impedance" design methodology. From the results, we conclude the necessity of studying the shape of output impedance in additional to the target impedance.

Future power distribution network requires additional attention to leakage resistance as the on-die leakage current keeps increasing. In the last section of this chapter, we propose to design and optimize the power distribution network with the consideration of constant and voltage-dependent leakage resistance path. We demonstrate that the leakage resistance can effectively affect the optimal resistor values in RLC tank model, when it is close to the same scale of the target impedance. Chapter 3, in part is a reprint of the material as it appears in "Ratio of the Worst Case Noise and the Impedance of Power Distribution Network", by Xiang Zhang, Yang Liu, Xiang Hu, and Chung-Kuan Cheng in *IEEE Transactions on Components, Packaging and Manufacturing Technology*, vol. 4, no. 8, pp. 1325-1334, Aug. 2014. The chapter also contains the content from "Worst-Case Noise Prediction Using Power Network Impedance Profile", by Xiang Zhang, Yang Liu, Ryan Coutts, and Chung-Kuan Cheng in *Proceedings of ACM/IEEE International Workshop on System Level Interconnect Prediction 2013.* The thesis author was the primary investigator and author of the papers.

Chapter 4

Worst-Case Noise Area Prediction of On-Chip Power Distribution Network

We propose a prediction of the worst-case noise area of the supply voltage on the power distribution network (PDN). Previous works focus on the worst-peak droop to sign off PDN. In this chapter, we (1) study the behavior of circuit delay over the worst-area noise, (2) study the worst-case noise area of a lumped PDN model, (3) develop an algorithm to generate the worst-case current for general PDN cases, and (4) predict the longest delay of a datapath due to power integrity. Experimental results show that the worst-area noise induces additional delay than that of the worst-peak noise.

4.1 Background

The aggressive advances in process technology increase the current demand and tighten the design rules. Such variation causes transistor delay [59], clock jitter [53] and many other negative effects, which degrade the overall performance [32]. As a result, PDN analysis becomes an important research topic [61]. PDN noise comes from the DC resistance and loop inductance of power/ground lines, which results in *IR* drop and inductive noise $(L\frac{di}{dt})$ at the load [55].

Figure 4.1 shows a typical PDN that consists of a voltage regulator module (VRM), PCB/package loop parasitics and on-die power grid with decoupling capacitors. A successful PDN design requires the power/ground loops presenting acceptable impedances at all frequencies of interest.



Figure 4.1: A typical circuit diagram characterizing the impedance of PDN.

Many previous works focused on the worst voltage drop in time-domain [18, 21, 34] and in frequency-domain [67, 36, 51] PDN analysis. Kouroussis *et al.* [41] proposed a vectorless approach for PDN integrity verification. This was later extended by Ferzli *et al.* [23] to a geometric approach for early estimation. Smith *et al.* [61] developed a method to systematically characterize the PDN noise. Ketkar *et al.* [33] studied micro-architecture based framework for PDN analysis. Chiprout [17] discussed pre-silicon stimulus and post-silicon activity generation to excite the

worst-case voltage drop. Abdul Ghani *et al.* [25] verified the PDN using node and branch dominance. Swaminathan *et al.* [30] used power transmission line to reduce the PDN noise.

Traditional PDN analysis concentrates on limiting the peak voltage drop. By applying constant supply voltage minus peak voltage on slow-slow(ss) corner transistors, designers may figure out the maximum drop that the critical path can tolerate to close the timing. However, this leads to an over-design as the duration of the peak drop of supply noise may be very short in real applications. Figure 4.2 shows two periodic supply voltage noise patterns applied to a datapath. The nominal delay of the circuit under $V_{dd} = 1V$ is D_0^{-1} . The dash curve has a peak voltage drop of 0.25V and noise area of 0.025T, which induces $1.11D_0$ signal delay. The dot curve has a peak voltage drop of 0.2V and noise area of 0.066T, which induces $1.23D_0$ signal delay. Due to larger noise area, the dot curve induces 11% larger delay, despite its 20% smaller peak noise.



Figure 4.2: A datapath of inverter chain under two supply patterns. The dash curve induces larger delay despite smaller peak noise.(period $T = T_1 - T_0$)

 ${}^{1}D_{0} \approx 100 ps$ according to our HSPICE simulation with 45nm PTM HP model [75].

In this chapter, we focus on the prediction of the worst-area noise of a PDN under a certain time window and the worst-case load current profile which generates the worst-area noise. We then predict the maximum circuit delay under such voltage noise profile. The importance of the noise area estimation on PDN analysis have been proposed and discussed by Intel [59] and Hashimoto's group on device level [52]. However, to the best of our knowledge, none of prior works provides quantitative analysis on the impact of noise area over the performance. Moreover, there is no prediction about the worst-case noise area.

4.2 **Problem Formulation**

We formulate the problem as maximizing the voltage noise area by designing current wave. A general PDN system, as Figure 4.1 shown, is characterized by the impulse response on the load node, *i.e.* h(t) (Figure 4.3(a)). Based on h(t) and a window size T, we design the current stimulus such that the voltage response has the maximum noise integral (area) within all possible intervals of length T on the time domain.

Current stimuli $i_k(t)$ at node k are caused by circuit activities. We lumped all the on-die load into a single load current i(t) for our analysis. As part of transistors are active at each time, the magnitude of i(t) varies within a range. The range is application dependent and can be approximated through the system-level simulation or post-silicon measurement. The assumptions of current constraints and zero transition time are used in many previous works [41, 23]. We follow the assumption of zero transition time and bound the total current demand by $i(t) \in [0, 1]$ in the rest of the chapter.

The voltage noise v(i, t) of the PDN system is the convolution of i(t) and

h(t) as Eq. 4.1.

$$v(i,t) = \int_0^{+\infty} h(\tau)i(t-\tau)d\tau \text{ s.t. } i(t) \in [0,1], t \ge 0$$
(4.1)

Note that we can scale v(i, t) accordingly once the upper bound of $i_k(t)$ is obtained.

The window size T is a constant, which refers to one clock cycle or other critical time period, in order to correlate with overall system performance. We slide the window along the timing-axis of v(i, t). The area of noise at each time tis defined as A(i, t), which is the integral of v(i, t) in [t - T, t].

$$A(i,t) = \int_{t-T}^{t} v(i,t)dt = \int_{t-T}^{t} \int_{0}^{+\infty} h(t-\tau)i(\tau)dt$$
(4.2)

The maximum voltage noise area of A(i, t) under window size T is defined as A_w . Current stimuli and time causing A_w are defined as $i_w(t)$ and t_w , respectively. Similarly, we define the worst-case voltage response as $v_w(t)$, on which A_w is obtained at t_w .

$$A_w = \max_{i,t} A(i,t) = A(i_w, t_w) = \int_{t_w - T}^{t_w} v_w(t) dt$$
(4.3)

We can develop an algorithm to solve the above problem in linear time, based on the simplifications as below.

- Binary-Valued Worst Current: We set i_w(t) as a binary-valued function (0 ∨ 1).
- Current Decomposition: For each load current, $i_w(t)$ can be decomposed into a series of step inputs $s(t - t_k)$ with constant amplitude (± 1) and monotonically increased phase delay. Here s(t) is a step input and t_k is



Figure 4.3: An example of PDN system with (a) the impulse response h(t), (b) the step response $V_s(t)$, (c) the ramp response $R_s(t)$ (integral of $V_s(t)$) and (d) the noise area function $A_s(t)$.

the phase delay of the k^{th} step input. Without loss of generality, suppose that $\{t_0, t_1, \ldots\}$ is in ascending order.

$$i_w(t) = \sum_{k=0}^{k} (-1)^k s(t - t_k) = \sum_{k=0}^{k} (-1)^k s_k(t)$$
(4.4)

To generate $i_w(t)$, we need to calculate the phase delay (t_k) of every step input (s_k) .

Voltage Area Responses of Single Step Input A_s(t): Figure 4.3(b) shows an example of the voltage response V_s(t) with a single input s_k(t). We observe that the integral within window size T on the step response can be formulated as a ramp response R_s(t) = ∫₀^t V_s(t)dt, as shown in Figure 4.3(c). We substitute Eq. 4.4 into Eq. 4.2 and define A_{sk}(t) = A(s_k(t), t) as follows.

$$A_{s_k}(t) = \int_{t-T}^t \int_0^{+\infty} h(t-\tau)(-1)^k s(\tau-t_k) d\tau dt$$

= $\int_{t-T}^t (-1)^k V_s(t-t_k) dt$
= $(-1)^k (R_s(t-t_k) - R_s(t-T-t_k))$ (4.5)

From Eq. 5.2, we can derive $A_s(t)$ by setting $t_k = 0$ thus $A_{s_k}(t) = A_s(t - t_k)$, which is illustrated in Figure 4.3(d). It corresponds to the definite integral of $V_s(t)$ in [t - T, t], as shown by the shaded area of Figure 4.3(b). Based on the definition of $A_s(t)$, the optimum phase delay sequence $\{t_0, t_1, \ldots\}$, and the optimum window location t_w , we can obtain the worst-case noise area A_w as follows.

$$A_w = \sum_{k=0} A_{s_k}(t_w) = \sum_{k=0} A_s(t_w - t_k)$$
(4.6)

Based on all the above definitions and simplifications, we formulate our problem as a linear-constrained linear optimization, which is concisely defined as below.

- Input:h(t) and window size T.
- **Output:** $\{t_0, t_1, \ldots\}$ and t_w , calculate $i_w(t)$ by Eq. 4.4.
- **Objective:** $A(i_w, t_w) = A_w$.
- Constraint: $i_w(t) \in [0, 1], \forall t \in [0, +\infty).$

4.3 Worst Noise Area Prediction of RLC tank: Analytical Solution

A typical PDN is a complex circuit model which can be approximated as the cascaded RLC tank models [67, 73]. We study the worst-case voltage noise area of an RLC tank model. We derive the closed-form expressions of the noise area from the ramp response of the model. The relations among noise area, quality factor, decaps C and it ESR R_2 are studied.

Let A(s), H(s) and I(s) denote the Laplace transform of A(i, t), h(t) and i(t), respectively. Eq. 4.2 can be written as

$$A(i,t) = \int_{t}^{t+T} v(i,t)dt \quad \xrightarrow{\text{Laplace}} A(s) = \frac{H(s)I(s)}{s}$$
(4.7)

Figure 4.4 shows a standard RLC tank. R_1 and L are used to model the parasitic resistance and inductance of the PDN interconnects. C and R_2 represent a decap with ESR_c .

The impedance profile of Figure 4.4 can be written as

$$Z(s) = \frac{s^2 L C R_2 + s(R_1 R_2 C + L) + R_1}{s^2 L C + s(R_1 + R_2)C + 1}$$
(4.8)



Figure 4.4: A standard RLC tank model

The quality factor, Q, and the resonant frequency, ω_0 , are

$$Q = \frac{1}{R_1 + R_2} \sqrt{\frac{L}{C}} , \quad \omega_0 = \frac{1}{\sqrt{LC}}$$
 (4.9)

For a normal PDN design with limited cost budge, $Q \ge 0.5$ and the RLC tank is underdamped. In the case of Q < 0.5, the PDN is over-designed with excessive decoupling capacitors which is not the scope of this chapter.

To derive the expressions for the worst-case noise area, we first study the step and ramp response of the model.

Lemma 4 The step response of an underdamped RLC tank is

$$V_s(t) = R_1 + 2e^{-\alpha t} [A\cos(\beta t) - B\sin(\beta t)]$$
(4.10)

where $\alpha = \frac{\omega_0}{2Q}, \ \beta = \sqrt{\omega_0^2 - (\frac{\omega_0}{2Q})^2}, \ A = \frac{1}{2}(R_2 - R_1), \ B = R_2 \frac{\frac{1}{2Q}(1 + \frac{Q_2}{Q_1}) - (Q_2 + \frac{1}{Q_1})}{2\sqrt{1 - \frac{1}{4Q^2}}},$ $Q_1 = \frac{1}{R_1}\sqrt{\frac{L}{C}}, \ Q_2 = \frac{1}{R_2}\sqrt{\frac{L}{C}}.$

Lemma 5 The ramp response of an underdamped RLC tank is,

$$R_s(t) = \int_0^t V_s(t)dt = R_1 t + \frac{1}{\beta} [K_1 \cos(\beta t) + K_2 \sin(\beta t)] e^{-\alpha t}$$
(4.11)

where
$$K_1 = \frac{R_1(Q^2Q_2^2 - Q^2 + 2QQ_2 - Q_2^2)}{QQ_2(Q - Q_2)} \sqrt{1 - \frac{1}{4Q^2}}, \ K_2 = -\frac{R_1(4Q^3Q_2 - 3Q^2Q_2^2 + Q^2 - 2QQ_2 + Q_2^2)}{2Q^2Q_2(Q - Q_2)}.$$

The ramp response R_s is derived from the integral of V_s . Based on R_s , the results lead to the following theorem.

Theorem 3 Given a window size T, the worst-case voltage noise area A_w of an underdamped RLC tank is,

$$A_w = \sum_{k=0}^n A_{s_k}(t_w) = \sum_{k=0}^n A_s(t_w - t_k)$$
(4.12)

where t_w is set to a relatively large value where $h(t) \approx 0$ and t_k is the time(phase delay) where local peaks/valleys of A_s occur, solved by equating the derivatives of A_s to zero. A_s can be expressed as follows

$$A_{s}(t) = \begin{cases} R_{s}(t) - R_{s}(t - T) & :t > T, \\ R_{s}(t) & :t \le T. \end{cases}$$
(4.13)

Since $A_s(t)$ is a piecewise-defined function upon the region of t (Eq. (4.13)), we can derive the results of t_k from the following two cases, (1) t > T and (2) $t \leq T$.

(1) For t > T, local peaks/valleys t_k are

$$t_{k} = \begin{cases} \frac{1}{\beta} (\arctan(\frac{A-X}{B-Y}) + k\pi) & : \frac{A-X}{B-Y} \ge 0\\ \frac{1}{\beta} (\arctan(\frac{A-X}{B-Y}) + (k+1)\pi) & : \frac{A-X}{B-Y} < 0 \end{cases}$$
(4.14)

where $k = 0, 1, ..., n, t_k > T, X = e^{\alpha T} (A\cos(\beta T) + B\sin(\beta T)), Y = e^{\alpha T} (A\sin(\beta T) + B\cos(\beta T)))$.

(2) For $t \leq T$, local peaks and valleys t_k occur at $R'_s(t) = V_s(t) = 0$, which

are the solutions of a transcendental equation,

$$R_1 + 2e^{-\alpha t} [A\cos(\beta t) - B\sin(\beta t)] = 0.$$

$$(4.15)$$

Because $\alpha > 0$, t_k occurs limited times when $t \leq T$. Plugging the results of Eq. (4.14), (4.15) back into Eq. (4.12), A_w can be derived.

4.4 Worst Noise Area Prediction for PDN Cases: Algorithmic Solution

We propose an algorithm to find the worst-case noise area for a general PDN profile extracted from the commercial tools. The pseudo-code of our method is presented in Algorithm 1. We use Figure 4.3 to illustrate each intermediate signal during the optimization. From the load current assumption in Section 4.2, we can decompose i(t) into n step inputs with constant amplitude ± 1.0 . To calculate $i_w(t)$ we only need to determine the phase delay of each step input. Given arbitrary impulse response h(t) and window size T, our algorithm is able to output t_w and all t_k such that A_w is achieved.

Design of Algorithm: The algorithm can be described as follows. Firstly, we convolute h(t) (Figure 4.3(a)) with step input s(t) and obtain the step response $V_s(t)$ (Figure 4.3(b)), then calculate the noise area function $A_s(t)$ (Figure 4.3(d)). To approach $i_w(t)$, we need to maximize (minimize) the contributions of all positive (negative) step inputs, which is no larger (smaller) than the sum of all peaks (valleys) of $A_s(t)$. Secondly, we extract all the peaks and valleys of $A_s(t)$ into $A_s(t_{pv})$. The leftmost and rightmost element of A_s will also be added to $A_s(t_{pv})$ if they are peaks. As every negative step input is sandwiched by two positive step

Algorithm 1 $[i_w, t_w, A_w] = GetWorstCase(h, T)$

- 1: **INPUT:** Impulse response h (length n), window size T
- 2: **OUTPUT:** Worst-case current wave i_w , window coordinate t_w , noise area A_w
- 3: Set V_s as the step response of h, $A_s[k]$ as the definite integral of V_s in [k, k+T)
- 4: Set $A_s(t_{pv})$ as peaks and valleys of A_s , $|t_{pv}| = 2m 1$
- 5: Set $A_w = \sum_{i=0}^{m-1} A_s(t_{pv_{2i}}) \sum_{i=0}^{m-2} A_s(t_{pv_{2i+1}})$
- 6: Set $t_{cur} = 0$ and $t_w = x_0 = t_{pv_{2m-2}}$
- 7: for all $x \in t_{pv}$ in reverse order do
- 8: $t_{new} = t_{cur} + (x x_0)$
- 9: if x is a peak then
- 10: Set $i_w[t_{cur}:t_{new}] = 1$
- 11: **else**
- 12: Set $i_w[t_{cur}:t_{new}]=0$ 13: **end if**
- 14: Set $x_0 = x$ and $t_{cur} = t_{new}$.
- 15: **end for**

16: return $[i_w, t_w, A_w]$

inputs, we have each valley in $A_s(t_{pv})$ be sandwiched by two peaks on both sides. Suppose there are m peaks thus m-1 valleys extracted, we have $|t_{pv}| = 2m-1$. Using t_{pv_i} to denote the j^{th} element of t_{pv} , A_w is calculated at line 5 as

$$A_w = \sum_{i=0}^{m-1} A_s(t_{pv_{2i}}) - \sum_{i=0}^{m-2} A_s(t_{pv_{2i+1}})$$
(4.16)

Thirdly, t_w is to the time of the last peak $t_{pv_{2m-1}}$ to make enough space for all step inputs to be correctly shifted. We calculate the phase delay t_k for each step input $s_k(t)$, and construct $i_w(t)$ as the superposition of them. Specifically, t_k is determined by the parity of k as below.

- **k** is even: Let $x = m \frac{k}{2}$, shift the k^{th} step input $s_k(t)$ by aligning the x^{th} peak of $s_k(t)$ to t_w . We have $t_k = t_{pv_{2x}}$.
- **k** is odd: Let $x = m \frac{k+1}{2}$, shift the k^{th} step input $s_k(t)$ by aligning the x^{th} valley of $s_k(t)$ to t_w . We have $t_k = t_{pv_{2x}}$.

Figure 4.5(a) demonstrates the method by which we determine the phase delay of each step input, notice that $s_k(t)$ is actually aligned to the t_w axis at $t_{pv_{2m-1-k}}$. Figure 4.5(b) shows how we construct $i_w(t)$.

Proof of Optimality: Given arbitrary (h(t), T), our algorithm always outputs $i_w(t)$ and t_w , with maximum noise area A_w .

Theorem 4 Our algorithm is optimum on maximizing A_w .



The proof of Theorem 4 can be found in Section S1.

Figure 4.5: The generation of t_k and $i_w(t)$ in terms of peak-to-valley distances.

Analysis of Complexity: The overall complexity of our method is O(n), as there are only finite operations included in Algorithm 1, while all of them are no more complex than linear. Here n is the length of the vector of the discretized PDN impulse response h(t). The value of n represents a trade-off between accuracy and efficiency of the optimization.

The proposed worst-case current prediction can figure out the worst-case peak noise and the worst-case noise area for general PDN cases.

4.5 Experimental Results

We implement our algorithm in Matlab R2013a. The circuit performance is simulated by HSPICE D-2013.03-SP1. Our test datapath is extracted from IS-CAS85 benchmark circuit with 0.13um standard spice model. All the experiments, including both the optimization and the simulation, are executed on a Windows 7 machine with an Intel if 3.4GHz quad-core CPU and 16GB memory. We design our experiments as follows.

- We study the relation of the circuit delay and the supply voltage noise area.
- We analyze the delay of a datapath under the worst-peak and the worst-area noise for a standard RLC tank model.
- We compare the results of the worst-peak and worst-area noise prediction between RLC tank analytical solutions and algorithmic solutions for complete PDN paths with cascaded RLC tanks.
- We measure the delay of a datapath under the worst-area noise of a complete PDN path extracted from commercial software tools.

4.5.1 Circuit Delay vs Supply Noise Area

The relation between the delay of a datapath and the supply noise area is investigated in this subsection. The test datapath is a customized circuit modified from C432 of ISCAS85 circuit. Delay between one input and output port are measured under various supply noise areas as shown in Fig. 4.6. The supply voltage fluctuates from 0.76V to 1.2V. The negative voltage area means the majority noise from droop, while positive represents the majority noise from overshoot. The end to end delay under constant 1V is normalized to 1. Results show that the delay increases quadratically as the voltage droop area increases.



Figure 4.6: Normalized delay of a datapath under different supply voltage noise area. (The delay under constant $V_{dd} = 1V$ is normalized to 1.)

4.5.2 Critical Path Delay under Worst-Area and Worst-Peak Supply Noises of an RLC Tank

We create a RLC tank model as shown in Figure. 4.4, where $R_1 = 10m\Omega$, l = 0.25nH, C = 33nF and $R_2 = 12m\Omega$. The nominal voltage and window size T are set to 1V and 17ns, respectively. The simulation time step is set to 0.5ns. Using Algorithm 1, We generate the worst area/peak load current, the worst area/peak voltage response and the voltage noise area responses as shown in Fig. 4.7. The worst peak noise is obtained by setting the window size to the minimum time step, *i.e.*, T = 0.5ns. Time causing the worst-case t_w for both the worst-area and worst-peak case are aligned to 500us in Fig. 4.7. The load current beyond 500*us* are set to 1. Fig. 4.7(a) confirms that the worst-peak load current is a constant square waveform with a frequency of β , while the worst-area load current is a piecewise-defined function. The segment before 499.983*us* is a constant square waveform with a frequency of β . The segment between 499.983*us* and 500*us* is determined by the solution of Eq. 4.15. Fig. 4.7(b) demonstrates the voltage response waveform for the worst-peak and the worst-area noise. Fig. 4.7(c) compares the voltage noise area of worst-peak and worst-area response under the same targeted window size T = 17ns.



Figure 4.7: Load current, voltage noise and voltage area of the worst-case peak and area of a standard RLC tank model, T = 17ns, (Nominal voltage 1V is superimposed in (b) and (c)).

We apply the waveforms between 499.9us and 500.1us from Fig. 4.7(b) as the supply voltages for the datapath used in the previous subsection. The delay of the datapath under constant 1V is 16.2ns. For the delay measurement, we send the input pulse every 100ps and record the delay at the output port as shown in Fig. 4.8. (Exp. 1 means that the input pulse starts at 499us. Exp. 1000 means that the input pulse starts at 500us.) Simulation results show that the maximum delay under the worst-area supply noise is 17ns, while the maximum delay under the worst-peak supply noise is 16.9ns. Our results confirm that the worst-area noise causes a worse circuit delay compared to the worst-peak noise.



Figure 4.8: The delay of the datapath under the worst-area and worst-peak noise of a standard RLC tank model (T = 17ns)

4.5.3 Worst-Area and Worst-Peak Noise of Multi-Stage Cascaded RLC Tanks

We use a multi-stage cascaded RLC tanks to model a complete PDN path. We study three multi-stage cascaded RLC tank PDN cases to compare the results from Theorem 3 and Algorithm 1. The circuit diagram of three cases are shown



Figure 4.9: Circuit diagram of a cascaded RLC Tank PDN

Table 4.1: The R,L,C parameters for three cascaded RLC tank cases

Cases	Ι	II	III
R1 $(m\Omega)$	5	38	5
R2 $(m\Omega)$	0.1	8	0.5
R3 $(m\Omega)$	3	2	5
R4 $(m\Omega)$	0.3	1.7	0.8
R5 $(m\Omega)$	5	10	10
R6 $(m\Omega)$	10	4.6	5
C1 (μF)	32	35	30
C2 (μF)	1.5	35.8	1.0
C3 (nF)	12	26.1	30
L1 (nH)	40	530	16.7
L2 (nH)	1.0	95	1.0
L3 (pH)	50	157	100

in Fig. 4.9 and the parameters are listed in Table 4.1.

The multi-stage cascaded RLC tank can be decomposed into multiple single RLC tank circuits in different frequency regions. (An example is given to show Case I in Table 4.1) are decomposed into three RLC tanks in Fig. 4.10.

Each tank contributes to a portion to the worst-peak and the worst-area noise. By applying Theorem 3 and Claim 5 in [73], we calculate the noise contribution of each tank and estimate the global noise peak and area as shown in Table 4.2. The RLC tank decomposition method provides a quick prediction on the worst area and peak noise from impedance profile directly. However, it tends to



Figure 4.10: Three standard RLC tanks to model a cascaded tank in Case I of Table 4.1

overestimate the voltage peak noise and voltage noise area due to the cancellation effect between neighbouring tanks. We observe a relatively large estimation error for Case II, which is because the impedance peaks of its first two tanks are close to each other. On average, the prediction error of RLC tank prediction method is 7.75% for the worst-peak noise and 12.3% for the worst-area noise.



Figure 4.11: The impedance profile of a complete PDN path $% \mathcal{F}(\mathcal{F})$

		4)	8			
Cases	Tank1	Tank 2	Tank 3	Tank 1,2 Valley	Tank 2,3 Valley	Total Est.	Alg. 3	$\operatorname{err}(\%)$
Case I $V_{peak}(V)$	0.1592	0.1263	0.1742	-0.008	-0.005	0.4467	0.4151	7.23%
Case I $A_w(V * ns)$	1.592	1.263	0.1366	-0.08	-0.05	2.8616	2.571	11.3%
Case II $V_{peak}(V)$	0.1614	0.0838	0.2406	-0.023	-0.012	0.4508	0.4050	11.31%
Case II $A_w(V * ns)$	1.614	0.838	0.7206	-0.23	-0.12	2.8226	2.363	19.45%
Case III $V_{peak}(V)$	0.0678	0.1047	0.1397	-0.016	-0.011	0.2852	0.2724	4.70%
Case III $A_m(V * ns)$	0.678	1.047	0.300	-0.16	-0.11	1.755	1.653	6.17%

Table 4.2: Comparison of the worst-case noise prediction between the RLC tank decomposition method and Alg. 3 results. T = 10ns for A_w .

4.5.4 Critical Path Delay under Worst Noise Area Fluctuation: a Test Case

We study the worst-area noise (T = 12.5ns) of a complete PDN path and the maximum detapath delay under the worst-area noise from a industrial design. The board model is extracted from Cadence Allegro Sigrity Power SI 16.6 and the package model is extracted from Ansoft Q3D 12.0. A fine on-die power grid model is used to simulated the die. The impedance profile of the complete PDN is shown in Fig. 4.11.

Plugging the impedance profile and T into Algorithm 1, the worse-peak and worst-area voltage response are shown in Fig. 4.12. Because the voltage droop of the complete PDN path is slightly high under our maximum current assumption (1(A)), we increase the nominal voltage to 1.15(V). Simulation results show that the worst-peak noise is 1.15 - 0.7779 = 0.3721(V) and the worst noise area A_w is 1.15(V) * 12.5(ns) - 12.21(V * ns) = 2.165(V * ns).



Figure 4.12: The worst-peak and worst-area current, voltage response and voltage area response (T = 12.5ns) of a complete PDN path. (d-f) shows the expanded view of (a-c) at the peak droop point.

The datapath extracted from C432 of ISCAS85 is slightly modified for the new window size by removing some circuitry. The results of delay measurement are shown in Fig. 4.13. We observe 0.22ns (1.8%) extra delay for the worst-area noise for this complete PDN path case. The comparison of the worst-area and worst-peak noise of this case are listed in Table 4.3.



Figure 4.13: The delay under worst-area and worst-peak supply noise for a complete PDN path (T = 12.5ns)

Table 4.3: Comparison of the worst-peak and the worst-area noise for a complete PDN path (T = 12.5ns)

	Worst-Peak	Worst-Area
Max Voltage Area (V*ns)	1.695	2.165
Delay of Datapath (ns)	12.33	12.55

4.6 Summary

In this chapter, we predict the worst-case voltage noise area and measure its impact on the circuit performance. We propose an analytical solution for RLC tank cases and an algorithm to find the worst-case current generation for general PDN cases. Our study shows that circuit delay is better correlated with the worstarea noise than the worst-peak noise. The former introduces on 1.8% additional propagation delay than the latter from our empirical validation under a complete PDN path.

Chapter 4, in full is a reprint of the material as it appears in "Worst-Case Noise Area Prediction of On-chip Power Distribution Network", by Xiang Zhang, Jingwei Lu, Yang Liu, and Chung-Kuan Cheng in *Proceedings of ACM/IEEE International Workshop on System Level Interconnect Prediction 2014.* The thesis author was the primary investigator and author of the paper.

S1. Proof of Optimality on the Phase Delay of the Worst-Case Current

The worst-case current $i_w(t)$ is a binary-valued function switching between 0 and 1. Based on this assumption, we prove that our algorithm could generate the optimum phase delay t_k for every step input $s_k(t)$, such that the superposition equals $i_w(t)$, as Theorem 4 shows. Fig. 4.5 shows that our algorithm determines t_k by the peak-to-valley distances in $A_s(t)$. Thus our target is to prove the correctness of Eq. (4.17), which is equivalent to the optimality of our algorithm as Theorem 4 shows.

$$A_w = \sum_{i=0}^{m-1} A_s(t_{p_i}) - \sum_{i=0}^{m-2} A_s(t_{v_i})$$
(4.17)

where $t_{p_i}(t_{v_i})$ represents the i^{th} elements of peaks(valleys). We prove the optimality by sequentially introducing the following lemmas. In the rest of the section, we assume $i_w(t)$ is decomposed into N step inputs. **Lemma 6** $\exists \{x_0, x_1, \ldots\}, s.t. A_w = \sum_{k=0}^{N-1} (-1)^k A_s(x_k)$

Proof 4 Based on Eq. 4.4, we can have $i_w(t)$ decomposed into N step inputs with constant amplitude ± 1 . Positive step inputs alternate with negative step inputs. Without loss of generality, suppose that the first step input is positive, and we have $i_w(t) = \sum_{k=0}^{N-1} (-1)^k s(t-t_k)$. Let $x_k = t_w - t_k$ and we have the lemma proved.

Lemma 6 shows that worst-case noise A_w equals the sum of a set of functional values sampled on $A_s(t)$, each with alternative sign of ± 1 . Let $X = \{x_0, x_1, \ldots, x_{N-1}\}$. As $A_w = \max_{i,t} A(i,t)$, we need to maximize the amount of positive components in $A_s(x_k)$ while minimize negative components, which leads to Lemma 7.

Lemma 7 $A_s(x_0)$ and $A_s(x_{N-1})$ must be positive.

Proof 5 We prove this by contradiction. Suppose that the sign of $A_s(x_0)$ is negative. We can simply remove x_0 from X thus reduce |X| to N - 1. Meanwhile, A_w will be increased by $A_s(x_0)$, which contradicts to the fact that A_w is maximum. As a result, we can prove that $A_s(x_0)$ is positive. The proof to the fact that $A_s(x_{N-1})$ is positive can be obtained in the similar way.

Lemma 7 shows the boundary conditions for A_s on X. We divide $A_s(t)$ into a series of *uphill* and *downhill* regions.

Definition 1 An uphill region (downhill region) corresponds to an interval on $A_s(t)$ with monotonically increasing (decreasing) functional values.

As Figure 4.14 shows, each uphill region is sandwiched by two downhill regions, vice versa. Suppose that there are m_p peaks and m_v valleys in $A_s(t)$, thus totally there are $m = m_p + m_v$ locally extreme points. The two end points of an uphill (downhill) regions are peak and valley (valley and peak), respectively. As a result, there are totally m - 1 regions on $A_s(t)$. For the j^{th} region r_j , we have $r_j = [t_{pv_j}, t_{pv_{j+1}}].$



Figure 4.14: Downhill region r_{j-1} is sandwiched by peak pv_{j-1} and valley pv_j , Uphill region r_j is sandwiched by valley pv_j and peak pv_{j+1} , etc..

Lemma 8 $\forall j \in [0, m-1], \exists k \in [0, N-1], s.t. t_{pv_j} = x_k.$

Proof 6 We prove this by contradiction. Suppose that there is no x_k in X which equals the index of the j^{th} extreme point pv_j . Without loss of generality, let us make the following assumptions.

- Suppose that pv_j is a valley, which is sandwiched by two regions r_{j-1} and r_j, as Figure 4.14 shows.
- Suppose that x_k is the sampling point which is the closest to t_{pvj}, and x_k > t_{pvj}. Thus we have t_{pvj} ∈ (x_{k-1}, x_k).
- Suppose that x_{k-1} corresponds to a negative step input s_{k-1}(t), while x_k corresponds to a positive step input s_k(t).

We divide all possible local sampling cases in the two neighboring regions of pv_j , r_{j-1} and r_j , into two categories.

- If $x_{k-1} \in r_{j-1}$, we can shift x_{k-1} rightwards to t_{pv_j} , thus increase A_w by $A_s(x_{k-1}) A_s(t_{pv_j})$, which contradicts to the fact that A_w is maximum.
- If x_{k-1} ∉ r_{j-1}, there must be no sampling point at pv_{j-1}. We can increase A_w by adding one positive point at pv_{j-1} and one negative point at pv_j, without changing the sign of any previous sampling points. This also contradicts to the fact that A_w is maximum.

Here we get the proof based on the above assumptions. As our proof and assumptions are general, the proofs for other conditions can be obtained in a similar way (e.g., pv_j is a peak, x_k corresponds to a positive step input $s_k(t)$, etc.) and are ignored here.

We define X_j to be the cluster of sampling points located in r_j . The two boundary points, t_{pv_j} and $t_{pv_{j+1}}$, are also included in X_j . Suppose that X_j is an uphill region, we define the noise area contribution of r_j to A_w as $A_w^j = \sum_{k=t_{pv_j}}^{t_{pv_{j+1}}} A_s(x_k).$

Lemma 9 A_w is maximum only if A_w^j is maximum, $\forall j \in [0, m-1]$.

Proof 7 The proof is straightforward. As both $t_{pv_{j-1}}$ and t_{pv_j} are included in X_j according to Lemma 8, we can only select or deselect the internal sampling points of r_j , which is independent with other regions. As a result, X_j is an optimum substructure for X, and we have Lemma 9 proved.

Based on Lemma 9, we only need to conduct local maximization of A_w^j on each X_j , and a global maximization of A_w is achieved, as Eq. (4.18) shows.

$$A_w = \sum_{j=0}^{m-1} A_w^j - \sum_{j=1}^{m-2} A_s(t_{pv_j})$$
(4.18)



Figure 4.15: A set X_j of n' local sampling points $\{x'_0, \ldots, x'_{n'-1}\}$ within region r_j .

Lemma 10 A_w^j is maximum when $X_j = \{t_{pv_{j-1}}, t_{pv_j}\}$.

Proof 8 We illustrate our proof in Fig. 4.15. Assume that there are n' sampling points in X_j where $X_j = \{x'_0, x'_1, \ldots, x'_{n'-1}\}$ in ascending order. From Lemma 8 we know that $x'_0 = t_{pv_{j-1}}$ and $x'_{n'-1} = t_{pv_{j-1}}$. Therefore, $n' = |X_j|$ is an even number, as X_j starts from a negative sampling point and ends at a positive point.

$$A_{w}^{j} = \sum_{k=0}^{n'-1} (-1)^{k+1} A_{s}(x_{k}')$$

$$= \sum_{k=1}^{\frac{n'}{2}-1} \left(A_{s}(x_{2k-1}') - A_{s}(x_{2k}') \right) + A_{s}(t_{pv_{j+1}}) - A_{s}(t_{pv_{j}})$$

$$\leq A_{s}(t_{pv_{j+1}}) - A_{s}(t_{pv_{j}})$$
(4.19)

The last step of Eq. (4.19) holds because r_j is an uphill region with monotonically increasing functional values. Therefore, we have $A_s(x'_{k_1}) \leq A_s(x'_{k_2}), \forall 0 \leq k_1 <$ $k_2 \leq (n'-1)$. From Eq. 4.19 we have $A_w^j \leq A_s(t_{pv_{j+1}}) - A_s(t_{pv_j})$, which proves the lemma.

Based on all the above proved lemmas, we finally obtain the following equation which proves Eq. (4.17) thus Theorem 4 and shows that our algorithm is optimum.

$$A_w = \sum_{j=0}^{m_p - 1} A_s(t_{p_j}) - \sum_{j=0}^{m_v - 1} A_s(t_{v_j}) = \sum_{k=0}^{N-1} (-1)^k A_s(x_k)$$
(4.20)
Chapter 5

Enhancing Off-Chip Communication Throughput from Power Lines

This chapter presents power line communication (PLC) to reuse some of the power pins as dynamic power/signal pins for data transmissions to increase the offchip bandwidth during SOC low performance state. The number of available pins in ball grid array (BGA) for modern system-on-chips (SOCs) is one of the major bottlenecks to the performance of the processors, for example many-core enabled Internet of Things (IoT) devices, where the package size and PCB floorplan are tightly constrained. A commercial SOC package allocates more than half of the pins for power delivery, resulting in less available IO pins for signaling. We observe that the requirement for the number of power and ground (P/G) pins is driven by the highest performance state and the worst design corners, while SOCs are in lower performance state for most of the time for battery life and thermal considerations. The proposed method provides 15Gbps additional bandwidth per hybrid pin pair, while providing minimum impact to the original power delivery network (PDN) design.

5.1 Background

As the silicon technology continues to shrink deep into sub-micron region, the requirement for performance and bandwidth increases. Meanwhile, the package size of SOCs remains similar as more functions are added to the silicon die and PCB manufacturing technology has been moderately improved, e.g., BGA ball to ball pitches are reduced from 0.4mm in 2012 to 0.3mm in 2016 in industry [57], while on-die technology node shrinks from 28nm planar silicon technologies to 10nm Finfet. Thus, the gap between off-chip bandwidth and on-chip bandwidth becomes even larger.

Many researchers in industry and academia have been working on addressing the limitations of the off-chip communications. 3D die-stacked technology [10, 14] and Package on Package (POP) [71] method have been proposed to expand the communication bandwidth from Z-axis. The concerns of those methods are 1) the cost increase on die and PKG manufacturing due to additional complexity for 3D integration, 2) heat accumulation (thermal issue) [48] and 3) Z-height constraints on the 3D integrations, as the-state-of-the-art mobile devices and laptops are very strict on PCB thickness for user experience. Proximity communication [76, 20] is investigated to improve off-chip communication through capacitive communication from package to package proximity, which requires advanced DFM (design for manufacturing) PCB rule for precise pick and placement to control the variance of the capacitance. Engin and Swaminathan proposed power transmission line [22], which eliminates the signal line and uses power net as a transmission line

CPU	GPU	Core	MEM	PAD	PLLs	MISC Pwrs	GND	etc.
28	36	40	53	38	35	56	283	425

 Table 5.1: Ball allocation for a commercial SOC [1, 2]

for the signal. However, the idea requires strict rules on power net layout and is limited by point to point communication. The shape of the actual PDN plane is layout-dependent, which is hard to achieve controlled impedance on the power planes. Meanwhile, the IR drop for power transmission line increases linearly when the current scales up. Chen *et al.* proposed to increase off-chip bandwidth for DRAM access by using switchable pins [15, 16]. The proposed architecture is to dynamically explore the surplus pins for power delivery in the memory intensive phases for providing extra bandwidth for memory/IO access. The implementation requires four external switches per switchable pin and greatly increases the layout complexity on PCB. Zhang *et al.* demonstrated the feasibility to implement single channel data communication on PDNs [74].

The state-of-the-art SoC comes with multiple performance modes for power savings and performance balance on multiple voltage domains. The difference of the voltage margins among various performance states can be as large as 500mV for mobile application processors (APs), so the PDN requirement can be significantly different. Traditionally, all the system-level PDN design and analysis are based on the highest performance mode (or the worst-case), resulting in more than enough power/ground pins allocated for the normal mode. Table 5.1 shows a package ball allocation for a commercial AP, where 57.24% out of 784 BGA balls are used for power delivery, leaving less than 40% pins for off-chip communications.

In this chapter, we propose a hybrid power and signal pins method to serve for power delivery and signal communication depending on the performance state, where we extend the previous work in [72] to support multi-channel data transmission on a PDN simultaneously. The proposed architecture increases the off-chip communication bandwidth, while maintaining no additional cost to the system level design. Our study shows that the communication bandwidth can be greatly improved by adding notches on PCB power planes and using separate package bump/ball connections for hybrid pins.

5.2 Design Overview

The proposed PLC reuses some power pins of core voltage rails for data communications in low performance state, leaving only a few dedicated power pins connected to the on-die power grid to meet the PDN requirement. The design target for PLC is to have the least modifications on the existing layout, while minimizing the coupling noise of data communication and power delivery noise, and maximizing the eye diagram and bit rate for data transmission. Considering that the PDN specification is usually in a range from DC to 2GHz, our targeted data communication frequency range is set to 2GHz to 50GHz.

Two types of SOC power pins are addressed for PLC. One is for the low current voltage domain for the dedicated macro blocks, such as for IO physical layers (PHYs), e.g. MIPI [5] and USB/HSIC [6], or for the noise sensitive rails, such as analog voltage for cameras or PLLs. Those rails are only powered upon request, and usually consume one ball/bump per rail, which are categorized as PLL rails in Table 5.1. Therefore, those pins for data transmission can be re-purposed in certain states. The benefit is that the dedicated traces on board and package are already allocated and the current requirement is small (in mA range). Thus, only a small head switch needs to be added to enable this function on the die level.

The other type is for high current voltage domains, e.g., CPU, GPU, core

logic and memory rails, which consume multiple power and ground pins for each rail and tie together on PCB/PKG through planes. Those rails usually support multiple performance states and the number of P/G pins is targeted for the highest performance state. Nevertheless, SOCs are in lower performance state for most of the time to save power. As a result, we propose to reuse some of the power pins (balls and bumps) for data communication in low performance state, leaving only a few dedicated power pins connected to the on-die power grid to meet the PDN requirement.

In this chapter, we focus on the design and analysis of PLC for high current rails, as it consumes the majority of power pins and can be a major resource to improve off-chip communication bandwidth. Figure 5.1 illustrates the high-level diagram of the proposed PLC. There are four main components, including voltage regulator module (VRM), SOC, off-chip driver/receiver and decoupling capacitors. VRM provides voltage for the SOC rails. Off-chip drivers/receivers communicate to SOC die through differential hybrid ball/bump pairs. As data communication and power delivery share the same conductors (copper) on PCB, we propose to use differential signaling (two pins for each channel) to minimize the noise to the dedicated power pins. The common mode voltage of the differential signals is set to the corresponding nominal voltage of the power plane. A layout modification is also required for package design to support PLC, where separate connections on package are made for the dedicated power bumps/balls and the hybrid ones. There are two operational modes for the hybrid pins, namely signal mode and power mode. In signal mode, the on-die power switches are turned off and the hybrid pins are used for off-chip communications. In power mode, the switches are turned on and the hybrid pins are connected to the main power grid. With the design challenge of the data communications of differential pairs and power



Figure 5.1: High-level overview of the proposed power line communication (PLC) on PDN.

delivery share the common conductors, part of PDN margin is compensated for better eye diagram.

5.2.1 On-Die Implementation

Figure 5.2 depicts the schematic of the proposed on-die circuitry of a differential hybrid power/signal pair, which is a modified circuitry from [15]. Two power switches are needed for each pair. R_{dson} of the switch can be as low as $1.8 \text{m}\Omega$ at an area overhead of $2601 \mu m^2$ [16].

In high performance (power) mode, both power switches are turned on, and the hybrid pins are connected to the main power rails. In signal mode, the power switches are turned off and the signal buffers are enabled in one direction according to the read/write operations. A multi-stage buffer can be placed for signal lines to amplify I/O signals to compensate the parasitic capacitance of the switch. A tunable on-die termination (ODT) resistor is provided for better signaling. A Continuous-Time Linear Equalizer (CTLE) is added to improve the eye diagram of the receiver. The design and performance of the CTLE will be discussed in the following sections.

The impact of parasitic capacitance $(C_{gs}, C_{gd}, C_{bs} \text{ and } C_{bd})$ of switch is considered as the main limiting factor for the eye height of signal mode as the drain of switches is shorted to power grid. While total parasitic C can be reduced by decreasing the size of transistors, R_{dson} increases which weakens the function of hybrid pins during power mode. The capacitance breakdown is shown in Figure 5.3.

In signal mode, since $V_{gs} = 0$ in cut-off region, $C_{gs} = C_{gd} = 0$ and C_{gb} is

$$C_{qb} = C_0/2 = WLC_{ox} \tag{5.1}$$

where C_{ox} is the capacitance per unit area of the gate oxide, L and W are the channel length and width, respectively.

The diffusion capacitance between source (drain) and body contributes parasitic capacitance across the depletion region.

$$C_{sb} = AS * C_{jsb} + PS * C_{jbssw}$$

$$C_{jsb} = C_J (1 + \frac{V_{sb}}{\Psi_0})^{-M_J}$$

$$C_{jbssw} = C_{JSW} (1 + \frac{V_{sb}}{\Psi_{SW}})^{-M_{JSW}}$$
(5.2)

where C_{jbs} (C_{jbssw}) is the capacitance of the junction between body and the bottom (side walls) of the source, C_J and C_{JSW} are the junction capacitance at zero bias, M_J and M_{JSW} are the unction grading coefficient, and Ψ_0 and PSI_{SW} depend on the doping levels.

Similar parasitic capacitance applies to drain as well, dependent on AD, PD and V_{db} . Equivalent relationships hold for both PMOS and NMOS transistors



Figure 5.2: The circuit diagram of an on-die differential-signal-to-power switch for PLC.

with different doping levels. It should be also noted that capacitances are voltagedependent.

Our studies show that by adding series resistors on gate of the switches can minimize the impact of the gate capacitance. However, the capacitance between source and drain of the switch cannot be compensated by series resistors, which is translated to DC resistance in power mode.

5.2.2 Package Implementation

The proposed PLC requires a package layout change on power delivery to improve SI of the hybrid pin in signal mode. Figure 5.4(a) shows the bumps and balls connections of power rails on a original package layout (Z-axis is enlarged for better illustration). A solid power fill on Layer 3 connects all the PWR bumps and balls through vias. For the modified package for PLC, a dedicated trace/plane is cut from the original power plane to connect each hybrid bump/ball pair, which



Figure 5.3: The capacitance model for a Mosfet.

creates the void areas on Layer 3 (1x minimum trace width spacing) as shown in Figure 5.4(b). The dedicated PWR bumps and balls are connected through a smaller plane on Layer 3. With the dedicated traces for each hybrid bump/ball pair, the differential signals can pass through packages with less attenuation. However, the additional void area on the power plane increases the parasitic inductance and resistance of PDN.

5.2.3 PCB Implementation

Figure 5.5 shows a four-layer PCB layout for PLC. The top and bottom layers are solid ground planes. The off-chip driver/receiver (P1-P4) with two channels and a 14x14mm SOC are located on Layer 1. In the center of top-left region, there are 7x7 P/G balls in checkerboard pattern allocated for a single power domain to minimize the loop inductance. Among them, four leftmost power pins are for two pairs of hybrid power pins for PLC, which connects to the SOC package balls,



Figure 5.4: A four-layer package (a) with the original shared power plane (b) with separate power planes for dedicated and hybrid pins for PLC.



Figure 5.5: An overview of the four-layer PCB test layout model for PLC.

while the rest balls are defined as dedicated power pins for noise observations. The port definition for S-parameter model is highlighted on Layer 1. All the following simulations follow this port definition. Layer 3 is allocated for signal transmission and Layer 2 is defined as the power plane.

When the off-chip driver sends out the differential signal from P1 and P2 for CH1, signal first travels through a Layer 1 to 3 via to the trace on Layer 3. The differential traces are loosely coupled on Layer 3 and the trace width is set to meet 1000hms of differential impedance (Z_{diff}) . The main power plane stays on Layer 3. The differential signal traces and power plane are connected through micro-vias from Layer 2 to 3. P5, P6, P7, P8 and other dedicated power pins are connected to the power plane through micro-vias from Layer 1 to 2. Therefore, P1 and P2, P5 and P6 are the PCB to package interfaces of the PLC between off-chip driver and SOC for CH1. VRM (P9) is not shown in the figure. To improve SI for data communication, layout modifications are needed on Layer 2 to isolate the current loop for dedicated and hybrid power pins, which will be discussed in the next section.

5.2.4 PCB Model Analysis

PCB model provides the most flexibility for PLC design. In this section, we use a theoretical four-layer PCB model (Figure 5.6) to analyze the PCB design methodology for PLC to better illustrate the idea. The top and bottom layers are solid ground planes (yellow). The off-chip driver/receiver and VRM are located at left and right side on Layer 1. SOC is located at the center of the board. The port definition for S-parameter model is highlighted on Layer 1. All the following simulations follow this port definition. The two leftmost power pads (P1 and P2) are represented as the off-chip driver/receiver. The two leftmost power pads (P3 and P4) are the differential pins for hybrid pair which connects to the SOC package balls, while the rest pads are defined as dedicated power pins for noise observations. For every power and signal pin, a companion ground pad is provided for the return loop. The differential signal traces are loosely coupled on Layer 2 and the differential impedance (Z_{diff}) is set to 100 ohms. The main power plane (red) stays on Layer 3. The differential signal traces and power plane are connected together through micro-vias from Layer 2 to 3. P3, P4,... and P10 are connected to the power plane through micro-vias from Layer 1 to 3. Therefore, P1 and P2, P3 and P4 are the PCB to package interfaces of the PLC between off-chip driver



Figure 5.6: An overview of a four-layer PCB test coupon layout for PLC.

and SOC.

Three notches are placed to Layer 3 to help improve SI of data transmission. We will study the SI/PI impact of location and size of those notches in the following sections. The PCB stackup is shown in Figure 5.7.

5.3 Signal Integrity Investigation for PCB Model

In this section, the optimization of PCB layout model for PLC is studied from the model in Figure 5.6. The goal is to maximize the magnitude and bandwidth of differential forward voltage gain (S_{dd21}) from P1 and P2, to P3 and P4 on PCB. There are a few parameters that can be tuned on the layout. Figure 5.8 shows an expanded view of power plane on Layer 3. Our layout studies

Stack Up	Pad Stac	k		
Layer #	Color	Layer Icon	Layer Name	Thickness(mm)
			Medium\$smt	0.035
1			Signal\$l1-gnd	0.0255373
			Medium\$dielectric1	0.0599999
2			Signal\$l2-sig	0.0204298
			Medium\$dielectric2	0.0599999
3			Signal\$l3-sig	0.0204298
			Medium\$dielectric3	0.2209
4			Signal\$l4-gnd	0.0255373
			Medium\$smb	0.035

Figure 5.7: The stackup of the test PCB layout.

are based on Mentor Expedition, Ansys Siwave and HFSS 2014, Sigrity 16.61 and Advanced Design System 2013.12. An Intel Xeon W3550 processor with 20GB memory computer is used for layout extractions and simulations.

The marked parameters in Figure 5.8 are the major factors for SI and PI. The width of the power fill (w) is set to 5.2mm to mimic a typical power plane for a mobile device layout. Parameters are defined as a=the length of two side notches, b=the length of the middle notch, d=the distance from the edge of the side notch to the center of the middle notch and e=the distance between the two differential (hybrid) pins. The width of the notch (w_n) and the length of via (l_{via}) have been studied as well. Considering the signal wavelength (λ) of 50GHz on a microstrip is 3mm, the signal discontinuity caused by any layout change under $\lambda/20$ (0.15mm) can be omitted. The minimum w_n is determined by PCB vendors, which is 50um under current technology. The maximum length of signal via l_{via} is 0.14mm according to the stackup. The length of the differential signal traces (l_{trace}) on PCB Layer 2 has also been examined. Simulation results show that as long as the Z_{diff} is controlled impedance, no SI difference is observed with different l_{trace} (Assuming a typical PCB size for mobile devices).



Figure 5.8: The definition of design parameters on Layer 3 of PCB.

5.3.1 Middle Notch Effect

In this section, we keep the middle notch between two hybrid differential power/signal pins and remove all the rest notches as Figure 5.9 shows. All the other PCB layers remain no change. From Figure 5.9(a) to 5.9(d), we monotonically decrease the length of the middle notch (parameter b). In Figure 5.9(e), the middle notch is totally removed. S_{dd21} are measured from off-chip driver (P1 and P2) to the SOC hybrid pins (P3 and P4) at PCB level for the five test cases. Figure 5.10 shows S_{dd21} of the five layouts.

We observe that the first valley of S_{dd21} moves towards higher frequency with a deceasing middle notch length. The corresponding wavelength (λ) of the first valley is equal to the average electrical length from one hybrid pin to the other. Eq 5.3 shows the relationship between the frequency of first valley (f_{valley}) and b.

$$f_{valley} = \frac{c}{\sqrt{\epsilon_r}} \frac{1}{2b + \alpha * w}$$
(5.3)

where c is the speed of light, and $\epsilon_r = 4.4$ is the dielectric constant of PCB. α is

a coefficient equal to 1.662 for the four notch cases. Table 5.2 shows the relation of b versus the calculated f_{valley} from Eq. 5.3 and from HFSS results for the four notch cases. In general, the mismatch of the calculation and simulation results is within 2%.

Case	b (mm)	f_{valley} from Eq. 5.3	f_{valley} from HFSS
Figure 5.9(a)	13.08	4.110GHz	4.104GHz
Figure $5.9(b)$	6.64	$6.525 \mathrm{GHz}$	6.506GHz
Figure 5.9(c)	3.14	9.586GHz	9.910GHz
Figure $5.9(d)$	1.51	12.27GHz	12.51GHz

Table 5.2: The length of the middle notch vs f_{valley}

Two conclusions can be drawn from this experiment. 1) b determines the cut-off frequency of PLC. The longer b is, the lower f_{valley} is. 2) The magnitude of S_{dd21} gets reduced if the middle notch is too short or removed.

5.3.2 Surrounding Notch Effect

In this section, six test cases are studied with the same b and different surrounding notches as shown in Figure 5.11. The first four test cases focus on varying the length of side notches (parameter a). Case 4 and 5 focuse on reducing parameters d and e compared to Case 3.

Figure 5.12 shows S_{dd21} for the above six cases. We observe that all six cases have a much wider bandwidth and higher gain compared to the previous five cases in Figure 5.10. Simulation results shows that as long as (a > b), there is no significant impact on S_{dd21} by tuning parameters a, as f_{valley} of Layout (0)-(3) are almost overlapping. We also notice that Case 5 has the largest bandwidth and the highest gain as its smallest parameter d among the six cases, which can be explained as follows. 1) The average electrical length is reduced due to the surrounding notches, which causes the signal to be transmitted in a more concentrated manner. 2) The



Figure 5.9: Five PCB test cases with different length of the middle notch on Layer 3.



Figure 5.10: S_{dd21} of the five cases in Figure 5.9.

Table 5.3: The length of the side notch vs f_{valley}

Case	d (mm)	f_{valley} from Eq. 5.4	f_{valley} from HFSS
Figure 5.9(a)	0.677	34.204GHz	34.13GHz
Figure $5.9(b)$	0.526	38.125GHz	38.75GHz
Figure $5.9(c)$	0.400	42.124GHz	41.74GHz

characteristic impedance of the power plane is increased due to the surrounding notches, thus reducing the reflection of the impedance mismatches from trace in Layer 2 to plane on Layer 3. 3) By adding side notches, Eq 5.3 can be modified as,

$$f_{valley} = \frac{c}{\sqrt{\epsilon_r}} \frac{1}{2b + \alpha * 2 * d}$$
(5.4)

where w is replaced by 2*d, $\alpha \approx \sqrt{2}$, and b=1.13(mm). Other parameters are the same as Eq 5.3. The difference of f_{valley} between Eq. 5.4 and simulations is less than 2%.



Figure 5.11: Six PCB test coupons with different size of the surrounding notches.



freq, Hz

Figure 5.12: S_{dd21} of the six test cases in Figure 5.11.

5.3.3 Analysis of PCB Model with industrial SOC Package Footprint

In industrial SOC package footprint, creating an artificial notch on PCB can greatly decrease the performance of PDN. However, in Figure 5.5 we observe that the beauty of checkerboard pattern between P/G balls can naturally create the needed notches for PLC. By decreasing the via connections to the power plane for the hybrid pins, the bandwidth and peak of S_{dd21} can be greatly increased as shown in Figure 5.13. Eq 5.5 shows the expressions of the frequency for the peak S_{dd21} . The peak magnitude of S_{dd21} is proportional to 1/C, where C is parasitic capacitance of the two pins.



Figure 5.13: S_{dd21} of two channels from the original and the modified power plane.

Items	CH1 two pins	CH2 two pins
Original Pin Resistance $(m\Omega)$	3.01, 3.16	3.11, 3.23
Modified Pin Resistance $(m\Omega)$	6.24, 6.37	6.17, 6.27
Original Pin Inductance (fH)	327.45, 340.37	347.59, 340.05
Modified Pin Inductance (fH)	1211.0, 1268.8	1101.2, 1155.9

 Table 5.4: Power pin impedance change for PLC

$$f_{peak} = \frac{c}{\sqrt{\epsilon_r}} \frac{1}{2D} \tag{5.5}$$

where c is the speed of light, $\epsilon_r = 4.4$ is PCB dielectric, and D is electrical distance between two hybrid pins.

5.4 Power Delivery Network Analysis

The PDN overhead of PLC comes from PCB, package and die level. Table 5.4 shows the pin resistance and inductance change between Figure 5.13(a) and Figure 5.13(b) from PCB level. With the pin changed to support PLC, effective DC resistance and inductance are increased by $3m\Omega$ and 700fH.

The PDN design overhead from PKG is caused by the separate power planes for each hybrid ball and bump pair. Depending on the different design and the selection of the location hybrid pair, the PDN impedance peak increase varies. The minimum pitch in state-of-the-art package design is 10um. Since power plane is 350um wide between two neighboring BGA assignment, the increase of resistance and inductance is 3%. Figure 5.14 shows a package layout where we cut the original whole power plane into five separate pieces to accommodate two hybrid ball and bump pairs. Light (green) is for ground and dark (red) is for power. Four separated planes are cut from the main power planes to accommodate each hybrid pin. The



Figure 5.14: A package power plane layout change for two hybrid pairs.

upper side vias are drilled down the balls and the bottom side via are connected up to the bumps. During the design, we intentionally select the balls and bumps from the outside ring of the power plane in order to minimize side effect to PDN.

The on-die PDN overhead is from the extra power switches for each bump of the hybrid pin. Larger size of the power switch increases silicon area overhead and input capacitance for PLC, thus degrading power performance of PLC. Under PTM 22nm HP model [7], we select R_{dson} for each switch to be $120m\Omega$ with an area overhead of $781um^2$.

5.5 PLC to PDN Noise Mitigation Analysis

As PLC shares the same conductor with PDN, we need to consider the noise coupled from the hybrid pins to the dedicated power pins in signal model. Conversely, the PDN noise to the data communication is less of a concern, as differential signaling is designed to cancel out the common mode noises. Layout 1 in Figure 5.12 is used for this study. As the PCB layout is symmetrical with respect to the middle notch, only the noise on the upper half of the power plane is

studied. The noise probe points are displayed in Figure 5.15. The max differential peak-to-peak voltage from the aggressors (hybrid pins) is set to 1V.

Two cases of the coupling noise are studied. 1) Off-chip driver is transmitter and SOC hybrid pair is receiver. 2) Off-chip driver is receiver and SOC hybrid pair is transmitter. The maximum absolute noise value observed at each probe point is listed in Table 5.5. We compare the noise results without on-board decoupling capacitors (decaps) and with four 0.01uF decaps connected at P9, P14, P18 and P22. Without decaps, P9 observes the worst noise because it has the maximum difference of the distance to the positive and negative pins (P3 and P4). The middle probe points (P6, P11, P15 and P19) have the lowest noise because their distance to differential hybrid pins is relatively the same. The coupling noise to a probe point can be greatly reduced by adding a small 0.01uF decap. We observe a higher voltage noise when SOC hybrid pins are transmitters. This analysis shows that decaps for the dedicated power pins can substantially minimize the coupling noise from PLC.

5.6 Case Study: A Complete Power Delivery and Data Communication Path

The effect of the on-die circuit to the performance of hybrid pins in signal mode is discussed in this section. Firstly, we demonstrate PLC on a complete PDN from PCB, package to die by investigating the eye diagram for pseudo-random binary sequence (PRBS) bit streams during the signal mode. The noise immunity of PLC is analyzed. Secondly, the impedance profile of the complete PDN path with PLC in power mode is demonstrated. The PCB model is in Figure 5.13(b). Package model is a modified industrial model for our proposed PLC. Die model is



Figure 5.15: The probe points for the noise coupled from the data transmission of hybrid pins to dedicated power pins.

	SoC RX		SoC TX	
Probe Point	No decap	4 decaps	No decap	4 decaps
P6	5mV	17mV	8mV	20mV
P7	44mV	40mV	74mV	48mV
P8	$53 \mathrm{mV}$	30mV	96mV	43mV
P9	64mV	34uV	111mV	34uV
P11	3mV	13mV	5mV	17mV
P12	24mV	18mV	$36 \mathrm{mV}$	24mV
P13	34mV	18mV	61mV	$26 \mathrm{mV}$
P14	43mV	8.4uV	79mV	9.5uV
P15	4mV	11mV	6mV	14mV
P16	14mV	12mV	$25 \mathrm{mV}$	$15 \mathrm{mV}$
P17	23mV	15mV	40mV	16mV
P18	$30 \mathrm{mV}$	15uV	53mV	14uV
P19	6mV	9mV	7mV	13mV
P20	11mV	11mV	17mV	13mV
P21	16mV	10mV	27mV	14mV
P22	21mV	26uV	35mV	22uV

Table 5.5: The maximum coupling noise at each probe point

extracted from PTM 22nm HP model.

5.6.1 Eye Diagram for Signal Mode

Figure 5.16 illustrates the schematic of the data path for one hybrid pair. PRBS is generated by the off-chip driver and connected to PCB through Port 1 and 2. Manchester code is used for self clock recovery and to avoid long '1' or '0' for DC offset. Port 5 and 6 are defined as PCB interface to hybrid pins to the package model. Port 10 to 13 are the dedicated power pins. Port 9 is connected to a local PCB decap with 2.2uF to represent a typical output capacitor of VRM for CPU/GPU rails. No decap is connected to the hybrid pin path for signal communication. By looking into S_{dd21} (from off-chip driver to SOC) of the combined PCB/PKG/die circuitry model, we determine 15Gbps as the bit rate for PLC using 30GHz signals with Manchester code.



Figure 5.16: Schematic for data communication on a PDN.



Figure 5.17: Eye diagram of a 30GHz (with Manchester code) PLC (a) without equalizer, (b)with equalizer.



Figure 5.18: The transfer function of the receiver equalizer.

Figure 5.17(a) shows the eye diagram of the signal received at the die level without or with the equalizer. The eye height is limited by the parasitic capacitance of the power switches from source to drain, because the drain of switches is short to the main power grid on the die level.

After investigating the transfer function of the channel, we designed a passive CTLE as shown in Figure 5.18 to improve the eye diagram. The equation of the CTLE can be expressed as follows.

$$H(s) = \frac{k(s-z)}{(s-p_1)(s-p_2)}$$
(5.6)

where k = 4.4.3982e + 11, z = 6.2832e + 07, $p_1 = 6.2832e + 10$ and 3.7699e + 11, which is equivalent to the following circuit as shown in Figure 5.19.



Figure 5.19: The circuit diagram of the receiver equalizer.

Figure 5.17(b) shows that the eye height was recovered three times larger.





Figure 5.20: Receiver eye diagram after equalization with near-end and far-end noise source from power plane.

The receiver can use simple peak-detectors and latch to regenerate the signal back to the original waveform. A positive going pulse is detected by the positive peak-detector. When it crosses the positive voltage threshold (+Vth), it sets the latch output to logic high. The output remains high until a negative pulse crosses the negative threshold (-Vth), of the negative peak-detector, and resets the latch to logic low.

The noise immunity of PLC is also investigated by injecting two noise sources at P3 (far-end) and P7 (near-end) individually. The noise source is a sine-wave at 30GHz with an amplitude of 100mV or 500mV. Figure 5.20 shows that PLC is immune from most of the noise sources on power plane and a near end noise can be barely observed at 500mV amplitude due to P/N phase skew.



Figure 5.21: Receiver eye diagram with and without equalizers when both channels transmit at the same time.

The use case when both channels transmit at 30GHz with PRBS Manchester Code simultaneously is studied. The receiver eye diagram of CH1 and CH2 with or without equalizers are shown in Figure 5.21. It can be concluded that the multiple data channels can be run on a single PDN simultaneously with negligible inter-channel noise under the proposed architecture.

5.6.2 PDN Analysis for Power Mode

The PDN during high performance mode is studied when all the hybrid pins turn on the power switches to connect with the dedicated power pins. Figure 5.22 shows the schematic of the original PDN and the modified PDN with one pair of hybrid pins. There is no notch on PCB and package on the original PDN.



(b) Modified PDN with one pair of hybrid pins and notches





Figure 5.23: Impedance profile for the original and the modified PDN with one pair of PLC.

The modified PDN is the same package and PCB model used in Figure 5.16. We assume the same value of PCB/PKG/die decaps for both cases. Figure 5.23 shows the impedance profile of the original and modified PDN for PLC. The PDN degradation is contributed by PCB and package, as a $5m\Omega$ higher impedance peak at the lowest frequency resonance is observed.

It can be inferred that with additional hybrid pairs added to PDN, the impedance peak could be further increased. Simulation results also show that increasing capacitors value on package and die can compensate the impedance peak jump due to hybrid pins. However, this would bring additional cost for the system design. As a result, designers should make judgment based upon the PDN design target and the off-chip bandwidth requirement to decide how many hybrid pairs to be added to a voltage rail.

5.7 Summary

In this chapter, we propose power line communication on industrial PDN for system-level SOC design. The bandwidth of each PLC channel can be as much as 15Gbps. Multiple power and ground pairs can be supported. The layout features and technologies to optimize the eye diagram of power line communication and maintain the PDN function are identified. The proposed PLC can substantially increase the off-chip bandwidth by re-purposing hybrid pins for signal transmission during IO-intensive benchmark.

Chapter 5, in part is a reprint of the material as it appears in "Enhancing Off-Chip Communication Throughput from Power Lines", by Xiang Zhang, Yang Liu, Ryan Coutts, and Chung-Kuan Cheng, which is submitted to *IEEE Transactions on Components, Packaging and Manufacturing Technology* and currently under review. This chapter also contains the content from "Boosting Off-Chip Interconnects through Power Line Communication", by Xiang Zhang, Ryan Coutts, and Chung-Kuan Cheng in *Proceedings of IEEE Conference on Electrical Performance Of Electronic Packaging and Systems EPEPS 2016* and the conent from "Power Line Communication for Hybrid Power/Signal Pin SOC Design", by Xiang Zhang, Yang Liu, Ryan Coutts, and Chung-Kuan Cheng in *Proceedings of ACM/IEEE International Workshop on System Level Interconnect Prediction* 2015. The thesis author was the primary investigator and author of the papers.

Chapter 6

Boosting Off-Chip Interconnects through Inter-Package Capacitive Proximity Communication

The chip to chip spacing for the state of the art electronic designs has been reduced due to the advances of design for manufacturing (DFM) technologies. In this chapter, we propose Inter-Package Capacitive Proximity Communication (IPCPC) to increase off-chip communication through the metal plate on the side wall of the chip packaging. We demonstrate IPCPC can transmit 20Gbps data on each channel and provide noise immunity to the coupling noise from adjacent channel.

6.1 Background

"Memory Wall", *a.k.a.*, the disparity between the rate of core performance improvement and the relatively stagnant rate of off-chip memory bandwidth, keeps

growing even larger. More and more transistors can be designed onto a single chip due to the advances of process node from 28nm planar silicon technologies to 7nm Finfet. Meanwhile, the package size of SOCs remains similar as more functions are added to the silicon die and PCB manufacturing technology has been moderately improved, e.g., BGA ball to ball pitches are reduced from 0.4mm in 2012 to 0.3mm in 2016 in industry [64, 57]. Future consumer electronic designs, including internet of things (IoT) devices, robotics, self-driving and mobile devices, require low latency and high bandwidth off-chip communications for memory access and sensor data analysis.

Researchers has been working on exploring new technologies onto systemlevel design to increase bandwidth, such as silicon photonics [28], wireless [70], 3D integration and System-in-Package(SiP) [64]. However, none of the methods comes without additional design for manufacturing (DFM) cost and risk, *i.e.* thermal, process variance and reliability. Switchable pins [16] for SOC have been proposed to dynamically allocate power pins for off-chip memory access at a cost of additional on-board external switches, bringing the extra cost to bill of materials and large PCB area overhead. Power line communication (PLC) [72] is proposed to transmit signals from power delivery networks(PDN).

In this chapter, we propose Inter-Package Capacitive Proximity Communication (IPCPC) to boost off-chip communication through the metal plates on the side wall of the package. Previous work, *i.e.*, Proximity [20] and Capacitive [49] Communication, has been proposed to enabling chip-to-chip capacitive communication from top or bottom side of the chip. Such proposed architecture weakens the mechanical structure of the chip, which is a major reliability concern for drop and torsion test. Our proposed method originated from the teardown of smartphone [8], where we observed that DFM rule for package to package separation is only 0.1mm, which enables the off-chip communication from the side wall of the packaging and brings no change to the mechanical structure of the package. Simulation results that IPCPC with $0.04mm^2$ parallel plates can support 20Gbps per channel bandwidth.

6.2 Design Overview




Figure 6.1 shows the high level diagram of IPCPC. The chip manufactured for IPCPC resembles to a traditional BGA flip chip, with the addition of array of metal plates exposed at the side walls for the package, *e.g.*, four metal plates in this sample, forming four data channels to the adjacent chip. To increase the capacitance, underfill (UF) is applied to increase relative dielectric constant. The conventional UF is made of bisphenol A or bisphenol F epoxy resin to enhance the reliability of a flip chip on PCB by redistributing the thermomechanical stress between the silicon chip and PCB substrate. Typical epoxy resin structure used in UF can be found in [64], with a dielectric constant in a range of 3.8 to 4.2. Ondie transmitter on one chip transmits the signal to metal plate through bumps, package buried vias, on-package trace, package buried vias and wire bonding to the surface of the metal plate, which AC coupled to the receiver chip. Same structure and channel connection is manufactured at the receiver side as well.

6.2.1 Capacitor Model Analysis

The capacitance model for IPCPC is shown in Figure 6.2. For the middle channel, C_{26} is the parallel plate capacitance between two middle plates. C_{12} , C_{23} , C_{56} and C_{67} are the capacitive crosstalk to adjacent channels, and $C_{12} = C_{23} =$ $C_{56} = C_{67}$ assuming the diameter of plates on two chips are the same. C_{bg} is the bottom side of the plate to PCB ground plane capacitance. C_{sg} is the total side-wall of the plate to PCB ground plane. C_{26} , can be calculated by the classic parallel plate capacitance, as shown in Eq. 6.1.

$$C_{plate} = \frac{\epsilon_0 \epsilon_k A}{dis},\tag{6.1}$$



Figure 6.2: High-level overview of the capacitor model for IPCPC

where ϵ_0 is permittivity of free space, ϵ_k is dielectric constant of the material between the plates, A is the area of the plate and dis is spacing between the plates. Similarly, C_{12} and C_{bg} can be estimated by Eq. 6.1 C_{sg} is a inclined plate capacitor, studied in [69], which can be extracted from Ansys Electronics Desktop Q3D/HFSS 2017. d is the distance between the plates from the two chips. d = 0.1mm, following the state of the art DFM rules. $\epsilon_k \approx 4$. The thickness of plates is t = 10um and the spacing between two neighboring plates on the same chip is $p \geq 50um$, b is the distance from bottom edge of the plate to PCB ground plane. According to the above design parameters, we can estimate that $C_{26} > 10 * C_{12}$.

Fig. 6.3 shows C_{26} and $C_{sg}+C_{bg}$ as a function of d. Capacitance is extracted at 10GHz and b is assumed to be 0.57mm. The trend of extraction is well correlated to calculation of C_{26} from Eq. 6.1. The extraction capacitance is slightly larger due to the effect of edge E-field of the plate, which is not considered in Eq. 6.1. Figure 6.3(b) shows that plate to ground plane capacitance slightly increases as d



Figure 6.3: (a)Plate to plate capacitance C_{26} vs d. (b)Plate to ground capacitance $C_{sg} + C_{bg}$ vs d.

increases.

Fig. 6.4 shows C_{26} and $C_{sg} + C_{bg}$ as a function of b. It can be concluded that C_{26} is proportional to the area of the plate. C_{26} also slightly increases as bincreases. $C_{sg} + C_{bg}$ initially drops quickly when C_{bg} is dominant, which is inversely proportional to b.



Figure 6.4: (a)Plate to plate capacitance C_{26} vs b. (b)Plate to ground capacitance $C_{sg} + C_{bg}$ vs b.

6.2.2 Manufacturing Tolerance

 C_{26} is dependent on manufacturing tolerance, as two chips (parallel plates) can be inclined (±5°) or d can be ±10%. From Fig. 6.4 we observe that C_{26} variance is less than ±10% as $d = 0.1mm \pm 10\%$. Meanwhile, the change of $C_{sg} + C_{bg}$ is less than ±5%.

6.3 Performance Analysis

Channel performance of the data communication is analyzed in this section. Assuming four metal plates as shown in Fig. 6.1, we build the model in ANSYS HFSS 2017 and simulate the 20GHz data communication eye diagram in Advanced Design System (ADS) 2013. The IO parasitics is extracted from IBIS model from Xilinx Virtex 7 [9]. d = 0.1mm, p = 50um and $\epsilon_k = 4.2$. The simulation setup is shown in Fig. 6.5. S_{15} , S_{26} , S_{37} and S_{48} are denoted for CH1, 2, 3 and 4, respectively. Data is transmitted at 20GHz.

6.3.1 The Size of the Metal Plate

The relation of channel signal integrity and the size of the plate are studied. The receiver eye diagram of the signal and crosstalk observed at the neighboring channel are shown in Fig. 6.6. Two sizes of plate are discussed. b = 0.67mm in the model. Increasing the area of the plate from $0.04mm^2$ to $0.09mm^2$ can increase the eye height by 56%. Meanwhile, the signal to crosstalk ratio also decrease from 6.4 to 4.9. Since a larger plate area comes at a cost of reduced total parallel plates that can be used for IPCPC, it is designer's discretion based on the requirement of bandwidth, transceiver, receiver, etc.



Figure 6.5: Simulation setup for channel performance for IPCPC.

6.3.2 The Distance from Metal Plate to PCB GND Plane

The relation of channel signal integrity and the size of the plate are studied. Plate size is set to $0.3 \times 0.3 mm^2$. Fig. 6.7 shows that as *b* increases, $C_{bg} + C_{sg}$ reduces, and channel signal integrity improves.

6.3.3 Transmitter Drive Strength (DS)

We further change drive strength (DS) R_1 from 33 Ω (Fig. 6.6(c)), to 20 Ω (Fig. 6.8(a)) and 50 Ω (Fig. 6.8(b)). Plate size is set to $0.2 \times 0.2mm^2$. We observe a large reflection at receiver with strong DS, and a reduced eye height margin with weak DS, which can be effectively used as a nub to improve signal integrity of IPCPC. It should be noted that Channel equalization, crosstalk compensation, coding and negative impedance control (NIC) can also be utilized to improve the channel performance of IPCPC.



Figure 6.6: Eye diagrams for signal and crosstalk observed at receiver and neighboring channel. (a) Signal for $0.3 \times 0.3mm^2$ plate, (b) Crosstalk for $0.3 \times 0.3mm^2$ plate, (c) Signal for $0.2 \times 0.2mm^2$ plate, (d) Crosstalk for $0.2 \times 0.2mm^2$ plate.

6.4 Summary

We propose IPCPC, a novel off-chip data communication method through inter-package capacitive coupling at a bandwidth of 20GHz per channel. The future work will focus on improve channel performance, increase the communication density of IPCPC by considering multiple rows of plate to plate communications.

Chapter 6, in full is a reprint of the material as it appears in "Boosting Off-chip Interconnects through Inter-Package Capacitive Proximity Communication", which is in preparation for *IEEE Conference on Electrical Performance Of Electronic Packaging and Systems 2017*, by Xiang Zhang, Dongwon Park and



Figure 6.7: Eye diagrams for signal with different *b*. (a) b = 0.07mm, (b) b = 0.57mm.



Figure 6.8: Eye diagrams for signal with different source drive strength (DS). (a) $R_1 = 20 ohm$, (b) $R_1 = 50 ohm$.

Chung-Kuan Cheng. The thesis author was the primary investigator and author of the paper.

Chapter 7

Conclusion

7.1 Summary of Contributions

In this dissertation, we study the system level PDN design and analysis, including worst-case PDN noise and prediction of single and cascaded RLC tanks, as well as PDN applications in timing analysis, leakage analysis, power line communications and capacitive communications. The contributions of this study are listed as follows.

Chapter 3 defines the ratio γ of the worst-case voltage noise and the maximum impedance of PDNs. The RLC tank models in real PDN structures are analyzed and the general method to calculate the worst-case noise in LC tank is discussed. The closed-form expressions of the worst-case noise in standard LC tanks are shown with theoretical upper boundary is proved. We demonstrate that γ in a complete PDN path can be greater than 1. We propose methods to predict the worst-case noise of the complete PDN path through cascaded LC tank model, and to calculate the PDN noise of a RLC tank model with voltage-dependent leakage resistance $R_{leak}(v(t))$ considered. We demonstrate the relation

of the optimal resistor value of RLC tank and leakage resistance R_{leak} .

Chapter 4 proposes a prediction of the worst-case noise area of the supply voltage on the power distribution network (PDN). First, we discuss the impact of the voltage noise area on the circuit performance and compare it with that of the peak voltage noise. Second, we study the closed-form expression of the worst noise area of a RLC tank case. Third, we develop an algorithm to generate the worst-case current stimulus for general PDN systems in O(n) time¹. Last, we investigate the circuit delay under a complete PDN path and design experiments to validate our methods.

Chapter 5 presents a differential power line communication (PLC) model to reuse some of the power pins as dynamic power/signal pins for data transmissions to increase the off-chip bandwidth during SOC low performance state. The proposed architecture increases the off-chip communication bandwidth, while maintaining no additional cost to the system level design. Key design parameters are identified to optimize the performance for PLC, and the parasitic capacitance of the power gating switches to the performance of data communication is studied. The theoretical model for receiver channel equalization is utilized to improve signal integrity. The noise immunity of PLC is investigated with multi-channel data transmission simultaneously. The peak impedance change of PDN contributed by the implementation of hybrid pins is investigated.

Chapter 6 demonstrates Inter-Package Capacitive Proximity Communication to boost off-chip communication through the metal plates on the side wall of the package at a bandwith of 20GHz per channel. First, the details of modeling and 3D extraction for the proposed architecture is demonstrated. Second, the

¹Here *n* refers to the vector length of the discretized impulse response of the PDN system. Full worst-case voltage waveform requires additional convolution of system impulse response and worst-case current, for which the total time complexity is O(nlog(n)).

performance and design tunable trade-off is discussed. Third, signal integrity and noise immunity to adjacent channel is studied.

7.2 Future Work

In state of the art circuit system design, PDN is usually over-designed with lots of redundancies (multiple caps, balls and bumps) and guard band considered for the worst-case voltage noises. One potential future direction is to define better metrics for real case PDN design and improve our proposed prediction method to save PDN design overhead to other functions in system integration. We have also been working on time-variant PDN components to dynamically mitigate the PDN noise by using adjoint network. Meanwhile, more design parameters can be added to model as well, such as the voltage derating for discrete capacitors, SOC thermal throttling impact to PDN, temperature variant on-die leakage resistance model and the global optimization for multiple voltage domain PDN design.

The other research topic is to scope out the advanced technologies to improve the performance of PLC and balance the tradeoffs to PDN while focusing on the further optimization of the on-die circuitry to minimize the impact from the parasitic capacitance of the power switches. Another direction is to use multiple rows of metal plates for high density chip to chip capacitive coupling communications.

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